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**Photovoltaic Devices Based on
 $\text{Cu}(\text{In}_{1-x}\text{Ga}_x)\text{Se}_2$ Nanocrystal Inks**

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**Photovoltaic Devices Based on
Cu(In_{1-x}Ga_x)Se₂ Nanocrystal Inks**

by:

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Dedication

For My Parents

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I hope everyone will benefit from my work. If I achieve something beyond my simple existence, it is because I was lucky to know such exceptional people.

Preface

Gloomy predictions of a future with energy shortages or a compromised environment are common for today's analysts and pundits. A future of 10 billion, relatively rich humans living comfortably on one planet is thought of as science fiction. The issue at the heart of such predictions is how closely quality of life has been tied to access to cheap and abundant energy resources. It is a remarkable correlation how richer societies need more energy and how development of new energy resources is followed by improvements in quality of life. With today's energy markets stretched to the limit, many fear promotion of 1 billion people, living today at sustenance levels, to middle class will create havoc on the environment or create shortages for wealthier populace of earth. Creating an egalitarian society for everyone will be a planetary challenge during my lifetime and an admirable goal. To see the future as a Malthusian trap is to discount the ingenuity of man (and woman) and ten millennia of precedence. I hope the work presented here will come to fruition and contribute to a brighter future.

Photovoltaic Devices Based on Cu(In_{1-x}Ga_x)Se₂ Nanocrystal Inks

Publication No. _____

Vahid Atar Akhavan, Ph.D.

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Supervisor: Brian A. Korgel

Thin film copper indium gallium selenide (CIGS) solar cells have exhibited single junction power conversion efficiencies above 20% and have been commercialized. The large scale production of CIGS solar cells, however, is hampered by the relatively high cost and poor stoichiometric control of coevaporating tertiary and quaternary semiconductors in high vacuum. To reduce the overall cost of production, CIGS nanocrystals with predetermined stoichiometry and crystal phase were synthesized in solution.

Colloidal nanocrystals of CIGS provide a novel route for production of electronic devices. Colloidal nanocrystals combine the well understood device physics of inorganic crystalline semiconductors with the solution processability of amorphous organic semiconductors. This approach reduces the overall cost of CIGS manufacturing and can be used to fabricate solar cells on flexible and light-weight plastic substrates.

As deposited CIGS nanocrystal solar cells were fabricated by ambient spray-deposition. Devices with efficiencies of 3.1% under AM1.5 illumination were fabricated. Examining the external and internal quantum efficiency spectrums of the devices reveal that in nanocrystal devices only the space charge region is actively contributing to the extracted photocurrent. The device efficiency of the as-deposited nanocrystal films is presently limited by the small crystalline grains (≈ 15 nm) in the absorber layer and the relatively large interparticle spacing due to the organic capping ligands on the nanocrystal surfaces. Small grains and large interparticle spacing limits high density extraction of electrons and holes from the nanocrystal film. A Mott-Schottky estimation of the space charge region reveals that only 50 nm depth of the nanocrystalline absorber is effectively contributing to the photogenerated current.

One strategy to improve charge collection involves increased space charge region for extraction by vertical stacking of diodes. A much longer absorption path for the photons exists in the space charge region with the stacked devices, increasing the probability that the incident radiation is absorbed and then extracted. This method enables an increase in the collected short circuit current. The overall device efficiency, however, suffers with the increased series resistance and shunt conductance of the device. Growth of nanocrystal grains was deemed necessary to achieve power conversion efficiencies comparable to vapor deposited CIGS films.

Simple thermal treatment of the nanocrystal layers did not contribute to the growth of the crystalline grain size. At the same time, because of the loss of selenium and increased trap density in the absorber layer, there was a measurable decrease in device efficiency with thermal processing.

For increased grain size, the thermal treatment of the absorber layer took place in presence of compensating amounts of selenium vapor. The process of selenization, as it is called, took place at 500°C in a graphite box and led to an increase of the grain size from 15 nm to several microns in diameter. Devices with the increased grain size yielded efficiencies up to 5.1% under AM1.5 radiation. Mott-Schottky analysis of the selenized films revealed a reduction in doping density and a comparable increase in the space-charge region depth with the increased grain size. The increased collection combined with the much higher carrier mobility in the larger grains led to achieved J_{sc} values greater than 20 mA/cm².

Light beam induced current microscopy (LBIC) maps of the devices with selenized absorber layers revealed significant heterogeneity in photogenerated current. Distribution of current hotspots in the film corresponded with highly selenized regions of the absorber films. In an effort to improve the overall device efficiency, improvements in the selenization process are necessary. It was determined that the selenization procedure is dependent on the selenization temperature and processing environment. Meanwhile, the reactor geometry and nanocrystal inks composition played important roles in determining selenized film morphology and the resulting device efficiency. Further work is necessary to optimize all the parameters to improve device efficiency even further.

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Chapter 1: Introduction*

Widespread utilization of solar energy as a viable alternative to hydrocarbon based electricity generation requires development of durable, low cost and highly efficient photovoltaic modules. Adoption of solar-electricity is hindered by the economics of photovoltaic module production. An economic figure of merit for photovoltaics is the ratio of how efficient a module is to what it costs to produce the said module. Significant progress has been made to increase this ratio, but a systemic shift is necessary to reduce the cost of solar-electricity to grid-parity levels. Many countries have placed a premium on a carbon neutral energy system and have subsidized adoption of photovoltaic electricity generation, even at today's high prices. Dependence of the solar electricity market on government subsidies highlights the need for a new generation of photovoltaic modules with high efficiency and low cost to promote a global adoption of solar-electricity production. The work presented here focuses on developing a new route to fabricate photovoltaics through solution processing of nanocrystal "inks".

1.1 Overview of Solar Cell Market

The average price of solar power is now \$0.21/kWh,¹ which is about three times the retail cost of electricity in the US.² At the moment, more than 50% of the total cost of

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photovoltaic (PV) electricity is associated with the price of the module, and grid parity requires significant reductions in solar cell manufacturing costs.^{3, 4} The solar cell market is dominated by crystalline silicon-based modules,⁵ and since 2004, the cost of these modules has decreased by only 5%.⁵ Significant price reductions for crystalline silicon-based solar cells have been slow because it is both a relatively mature technology with largely optimized device efficiency,^{3, 6} and the raw materials costs are significant. The cost of silicon alone contributes as much as 50% of the module cost and 28% of the total cost¹ because very thick silicon layers of more than 500 μm are needed (silicon is a very inefficient light absorber) and the competition for highly purified electronic grade silicon with the microelectronics industry keeps the price of silicon high.⁷

1.2 Alternatives to Silicon

A “second generation” of silicon-alternative PV technologies that utilize thin absorber layers has been developed, utilizing materials like amorphous silicon, CdTe, and copper indium gallium selenide (CIGS).^{8, 9} The device efficiencies are not quite as high as those using crystalline silicon, but the manufacturing costs are significantly lower.¹⁰ The cost of solar power depends roughly on the ratio of the efficiency to the manufacturing and installation costs, making these technologies competitive with silicon, and now garner about one-third of the PV market share.⁵ First Solar’s new CdTe PV technology has recently been reported with a production cost of only \$0.98/W_p,¹¹ just below the \$1/W_p level that many considered the target for grid parity.

The manufacturing processes for these silicon alternatives nonetheless are still relatively slow and expensive, requiring high temperature processing steps that make an

order of magnitude reduction in manufacturing cost unlikely. New approaches, with the potential for dramatic reductions in cost, are desired.

1.3 Third Generation Photovoltaics and the Printed Inorganic Thin Film Solar Cell

At the moment, a materials system and processing approach with the potential for both high efficiency and ultralow cost has not been identified. Such a technology would most likely need to be compatible with high-throughput roll-to-roll deposition and inexpensive plastic flexible and light-weight substrates.¹⁰ The “third generation” PV devices would yield efficiencies above 10%, as needed for commercial viability, but with dramatically reduced manufacturing costs.⁹

One target has been to create a technology for fabricating plastic disposable solar cells. As a step in this direction, photovoltaic devices made with organic light-absorbing materials have been made—so-called organic photovoltaics (OPVs)— with efficiencies as high as 7.4%.¹² For commercial viability, the device efficiency must still be improved and the materials costs for these record devices are in fact relatively expensive. And there is a concern about long-term OPV device stability under the typical operating conditions in the field.

Another approach to PV fabrication that has the processing attributes of organic materials, but combines the proven device performance and stability of inorganic materials, is to formulate nanocrystal inks that can be deposited under mild conditions using high throughput continuous processes like roll coating, spray-coating, spin coating, dip-coating, drop casting, ink-jet printing, doctor-blading, screen printing, etc.¹³ If solar cells could be made without the need for high temperature or high vacuum processing,

these inks could dramatically lower solar cell module manufacturing costs. A light-weight solar cell on plastic would also significantly lower the installation costs. Since the module price accounts for only half of the total solar energy cost, this is a very important consideration.³ The conventional solar cell fabrication processes, requiring high temperature, must be carried out on heavy glass or metal supports, which comprise the majority of the weight in commercial solar modules. Light and flexible panels would change the way solar cells are installed, enabling more efficient transportation and installation. The “panels” could be unrolled like a carpet and mounted on residential rooftops with no need for mounting brackets and structural reinforcement to the roof.

1.4 Nanocrystal Ink Formulation

Chemical methods have been developed to synthesize nanocrystals of many different materials suitable for PV devices. The nanocrystals are made by a process called arrested precipitation. Chemical reactants are decomposed in a solvent in the presence of “capping ligands” that bond to the nanocrystal surface as illustrated in Figure 1.1. The capping ligands are an integral part of the nanocrystal formulation, enabling good dispersion in solvents by preventing aggregation. This is important for uniform film deposition and device fabrication.

Many research teams have now demonstrated that it is indeed possible to print inorganic layers of light-absorbing semiconductors from nanocrystal inks and make functioning solar cells. Nanocrystals of cadmium and lead based chalcogenides (i.e. CdS, CdSe, CdTe, PbS, PbSe, and PbTe) have been incorporated into PV devices with reasonable efficiencies between 2% and 5%.¹⁴⁻¹⁹ Cu₂S solar cells made from a

nanocrystal ink has also been made, with efficiencies of up to 1.6%.²⁰ And nanocrystals of relatively complicated composition have also been synthesized, including tertiary and quaternary compounds.²¹⁻²⁵ Of these materials, some of the most interesting have been copper indium gallium selenide (CIGS)^{21, 22} and copper zinc tin sulfide (CZTS),^{23, 24} as these are proven solar cell materials and do not face the same negative environmental implications as widespread Cd and Pb incorporation into solar cells. Table 1.1 lists the published work on PV devices with nanocrystalline absorber layers. A wide variety of geometries and architectures have been built with many different nanocrystalline inks. The resulting devices based on as-deposited nanocrystals, however, have relatively small efficiencies. Recent research has aimed to improve the performance of the devices using new geometries to increase carrier conduction through the nanocrystalline films. Grain growth based on thermal treatment has been the most successful attempt at increasing the efficiency of the devices, and an overview of published work is presented in the second part of table 1.1.

1.5 CIGS Nanocrystal Inks

More details on the synthesis of CIGS nanocrystals and device fabrication are presented in chapters 2 and 3. To date, the highest device efficiency achieved by a photovoltaic device fabricated by nanocrystal ink deposition is just over 10%, reported by Hillhouse and Agrawal for CIGS.²⁶ This work provides an important and encouraging benchmark for PV devices made using nanocrystal inks, and has demonstrated that nanocrystal inks can indeed provide commercially viable efficiencies. There is a catch however, in that these efficiencies were achieved by annealing the films at rather extreme

temperatures, exceeding 500°C, under Se atmosphere. This type of processing significantly increases grain size, and leads to improved electronic conduction within the absorber films. Such extreme processing conditions, however, make it impossible to fabricate devices by a roll-to-roll process, or on cheap plastic substrates. Nonetheless, CIGS is a particularly interesting semiconductor for a nanocrystal ink-based approach to solar cell fabrication.

Table 1.1. Summary of the reported device efficiencies of PVs with nanocrystal-based absorber layers deposited without high temperature or vacuum processing. Reproduced with permission from Akhavan et. al. (*In Press*) Copyright 2011 Elsevier.

Nanocrystal Material	Device Geometry	η (%)	Jsc (mA/cm ²)	Voc (mV)	FF	Eg (eV)	Ref.
CuInSe ₂	Au/ CuInSe₂ /CdS/ZnO/ITO	3.1	16.3	410	0.46	0.9	27
CdSe & CdTe	Ca/ CdTe/CdSe /ITO	2.9	13.2	450	0.49	1.5	14
Cu ₂ S-CdS	Al/ CdS/Cu₂S /ITO	1.6	5.63	600	0.47	1.3	20
PbSe	Mg/ PbSe /ITO	1.1	17	230	0.40	1.0	17
PbSe	Al/Ca/ PbSe /ITO	2.1	24.5	240	0.41	0.95	15
PbSe	Au/ α -NPD/ PbSe /ZnO/ITO	1.6	15.7	390	0.27	1.1	28
PbS	Al/a-Si/ PbS /ITO	0.7	9.0	200	0.39	1.1	29
PbS	ITO/ PbS /LiF/Al/Ag	3.9	14.5	460	0.64	1.1	30
PbS & ZnO	ITO/ ZnO/PbS /MoO _x /Al	4.4	18.1	524	0.46	1.5	31
PbS & TiO ₂	SnO ₂ :F/ TiO₂/PbS /Au	5.1	16.2	510	0.58	1.3	19
PbSe _x S _{1-x}	Al/ PbSe_xS_{1-x} /ITO	3.3	14.8	450	0.5	1.0	16
PbSe & ZnO	ITO/PEDOT/ PbSe/ZnO /Al	3.4	24.0	440	0.32	1.4	18
CuInSe ₂	Mo/ CuInSe₂ /CdS/ZnO/ITO	0.24	3.2	300	0.25	1.0	21
CZTS	Au/ CZTS /CdS/ZnO/ITO	0.23	1.95	320	0.37	1.5	23
CuInS ₂	ITO/ CuInS₂ /CdS/Al	4.0	12.4	590	0.55	1.5	32
Cu(InGa)Se ₂	Mo/ CIGS /CdS/ZnO/ZnO:Al	2.6	17.3	305	0.50	<1.1	33
SnS & TiO ₂	SnO ₂ :F/ TiO₂/SnS /Pt	0.10	0.30	470	0.71	1.3	34
<u>Nanocrystal Absorbers Sintered at High Temperatures</u>							
CuInSe ₂	Mo/ CuInSe₂ /CdS/ZnO/ITO	2.8	25.8	280	0.39	1.0	22
CIGSSe	Mo/ CIGSSe /CdS/ZnO/ITO	5.5	23.7	460	0.51	1.1	25
CZTS	Mo/ CZTS /CdS/ZnO/ITO	0.8	11.5	210	0.33	1.5	24
CZTSSe	Mo/ CZTSSe /CdS/ZnO/ITO	7.2	31.2	430	0.54	1.4	35
CZTGeSSe	Mo/ CZTGeSSe /CdS/ZnO/ITO	6.8	21.5	640	0.49	1.1	36
CdTe	ITO/ CdTe /ZnO/Al	6.9	20.7	590	0.56	1.44	37

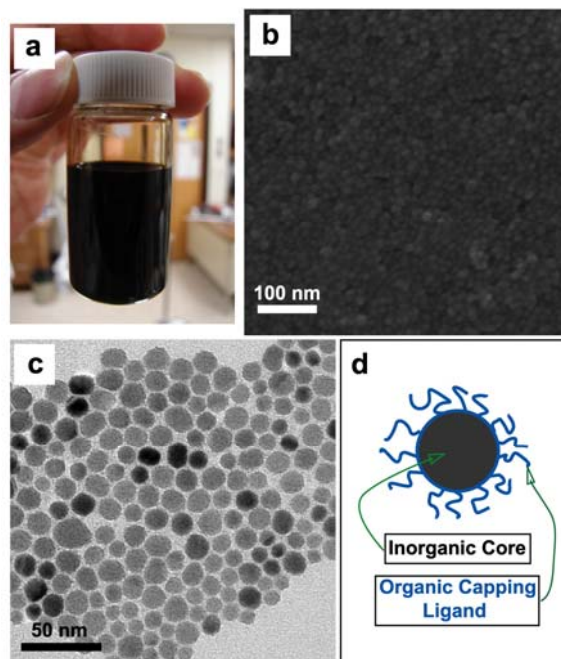


Figure 1.1. (a) Photograph of a CIGS nanocrystal ink; (b) a large-area scanning electron micrograph of a nanocrystal film deposited by spray-coating the ink; (c) transmission electron micrograph of CIGS nanocrystals; and (d) an illustration of a nanocrystal, that depicts the inorganic crystalline core coated by the organic capping ligand layer that stabilizes the nanocrystals.

Single-junction CIGS cells fabricated using state-of-the-art high temperature vacuum deposition processes have achieved device efficiencies of 20% PCE.^{38, 39} These devices are made with polycrystalline films, so these very high efficiencies are rather remarkable. Theoretical calculations and experimental analyses have shown that polycrystalline CIGS films can behave similar to a perfect single crystal in terms of minority carrier transport.^{40, 41} Since nanocrystal-based films inherently have very high concentrations of grain boundaries, this property of CIGS makes it a promising material for a nanocrystal ink approach to solar cell fabrication in terms of potentially achieving commercially viable efficiencies.

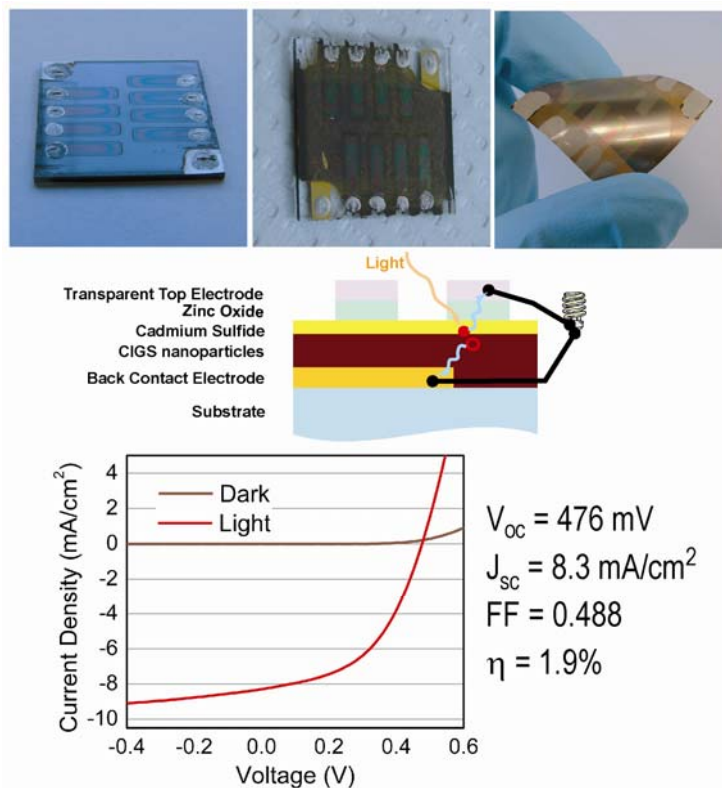


Figure 1.2. (Top panel) Solar cells made by spray-coating CIGS nanocrystal inks on various substrates: on glass with either (top left) molybdenum or (top middle) gold back contacts, and (top right) on plastic (Kapton). (Middle) Schematic showing the layer structure of a PV device; in this case, light is absorbed by the CIGS layer and electron-hole separation leads to photogenerated power. (Bottom) An example of the device characteristics obtained from a PV device made with a CuInSe_2 nanocrystal ink. The open circuit voltage (V_{oc}) and fill factor (FF) of the device are similar to those of commercially available CIGS cells; however, the short circuit current density (J_{sc}) is only 25% of the expected value for an absorber material with this bandgap, resulting in the low device efficiency (η).

Quaternary elemental stoichiometry and specific crystal structure of CIGS film make the vacuum deposition process very challenging across large substrate areas.¹⁰ In this context, nanocrystal inks can be synthesized with the desired composition and stoichiometry and then deposited from the ink onto the substrate. In fact, we've demonstrated that that CIGS layers with controlled stoichiometry can be spray-painted in

air at room temperature with nanocrystal inks, and that these films can be used to construct PVs with efficiencies of about 3% without any high temperature post-deposition processing.²⁷ The same concept has been demonstrated with CZTS nanocrystals as well.²³ The inks make it possible to deposit semiconductor absorber layers of materials with complicated phase behavior that are difficult or may even be impossible to deposit effectively by vapor-phase processes.

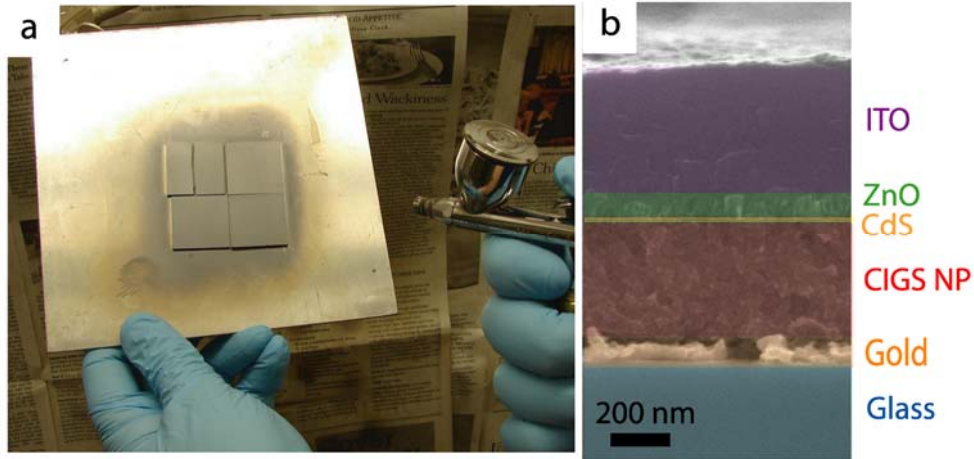


Figure 1.3. (a) Photograph of the spray deposition of a nanocrystal ink into a PV device. (b) Cross-sectional SEM image of a completed device.

Figure 1.2 shows typical response of nanocrystal CIGS devices. The device layers exhibit the desired compositional uniformity; however, the significant presence of grain boundaries between particles in the absorber layer limits the device efficiency. These printed inorganic PVs exhibit open circuit voltage and fill factor near those made by vapor deposition processes, but the short circuit currents are much less than those of state-of-the-art CIGS devices (Figure 1.2). Electrons and holes are trapped at interfaces

between the nanocrystals in the absorber film, leading to losses in efficiency. It is encouraging, however, that the nanocrystal inks can be deposited on any type of support (Figure 1.3) to fabricate PV devices and achieve similar efficiencies. The key issue to address is the role of the grain boundaries and how to passivate them. The following chapters detail characteristics of nanocrystal based devices, provide answer to some of the limitations facing the nanocrystal based devices, provide the details of how to achieve significant grain growth in the nanocrystal films and provide a workable strategy to achieve high efficiency devices based on solution processing of nanocrystalline grains.

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Chapter 2: Spray-Deposited CuInSe₂ (CIS) Nanocrystal Photovoltaics*

2.1 Introduction

Crystalline silicon solar cells dominate worldwide sales of photovoltaic devices (PVs), yet remain relatively expensive. Thin film PVs with lower manufacturing cost, like amorphous Si, copper indium gallium diselenide (CIGS) and CdTe, are gaining marketshare, but still require significant cost reductions to enable widespread adoption.¹ Here, we report the development and use of an ink of copper indium diselenide (CIS) nanocrystals that can be spray-coated under ambient conditions onto various substrates to fabricate PVs. This materials system is compatible with high throughput roll-to-roll processing on plastic substrates.

CIGS is a particularly good semiconductor for PVs: it has a very high optical absorption coefficient, good photostability, and an optical gap that is well-suited for high efficiency single junction devices that can be tuned between 1.04 and 1.68 eV by manipulating the Ga content.² Vapor-deposited CIGS PVs have demonstrated power conversion efficiencies as high as 19.9%³ and are being commercially produced.⁴ The CIGS layers in commercial devices, however, are deposited by a relatively expensive multistage coevaporation process that requires high temperature and vacuum. In practice, it is difficult to control the stoichiometry of the film over large device areas using these processes, which ultimately leads to elevated manufacturing cost,⁵ as small deviations in

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stoichiometry across the film leads to variable device performance.⁶ CIGS PVs have also been made on flexible substrates, with efficiencies as high as 12.8%;⁹ however, the processes used for those devices are not compatible with light-weight plastic substrates and the highest efficiencies require sacrificial rigid supports, vacuum processing and high temperature deposition.¹⁰ A single-step layer deposition technique that does not require high temperature or vacuum, utilizes a high percentage of raw material input, that is compatible with roll-to-roll processing on flexible plastic substrates, and enables improved process automation would greatly reduce the overall cost of manufacturing CIGS PV devices.⁸

Recently, PVs with CIGS absorber layers have been made using nanocrystal-based inks deposited under ambient conditions.¹¹⁻¹² Synthetic methods for colloidal CIGS nanocrystals with chalcopyrite structure and targeted stoichiometry have been developed, in which Cu, In, Ga and Se reactants are combined into one pot in a high boiling solvent and heated in the presence of a capping ligand, oleylamine.¹¹⁻¹² The ligand-coated nanocrystals readily disperse in organic solvents and can be cast onto substrates under ambient conditions. We have demonstrated that CIS nanocrystal-based PVs can be fabricated with these materials, but with very low efficiency, of less than 0.3%.¹¹ Recently, Hillhouse and Agrawal demonstrated that high temperature (>500°C) selenization of CIS-based nanocrystal films can be used to achieve PV efficiencies nearing 10%, but the use of the high temperature annealing process eliminates the possibility of roll-to-roll processing on plastic substrates.¹²⁻¹⁴

Here, we demonstrate significant improvement in the single junction PV efficiency of spray-coated CIS nanocrystal PVs that have not been processed using high

temperature or vacuum, with power conversion efficiencies of up to 1.9% under AM 1.5 simulated sunlight. CIS nanocrystal films were deposited by spray-coating onto bottom-contact supports of glass or plastic, and then finished with CdS and transparent conductive oxide. The mild deposition conditions of the CIS absorber layer also enabled PV fabrication on a variety of alternative substrates, including flexible kapton polymer (power conversion efficiency of 1.2%) and transparent conductive indium tin oxide (ITO) (power conversion efficiency of 1.1%). The efficiency of the spray-deposited CIS nanocrystal PVs was found to be limited by inefficient electron/hole separation and transport in the nanocrystal layer, and the highest efficiencies were obtained from relatively thin devices that absorb only a fraction of the incident sunlight. An approach to increased efficiency by stacking devices with transparent contacts is demonstrated.

2.2 Experimental Details

2.2.1 Chemicals

Oleylamine (OLA; >70%), tributylphosphine (TBP; 97%), copper(I) chloride (CuCl; 99.995+%), indium(III) chloride (InCl₃; anhydrous 99.99%), elemental selenium (99.99%), cadmium sulfate (CdSO₄, 99.999%) from Aldrich Chemical Co.; ammonium hydroxide (18M NH₃, ACS certified), toluene (99.99%), ethanol (absolute), from Fisher Scientific; and thiourea (99.999%) from Fluka. Oleylamine was degassed by three cycles of freeze-pump-thaw. All other chemicals were used as received without further purification. Copper(I) chloride, indium(III) chloride, TBP and degassed OLA were stored in a nitrogen-filled glovebox to prevent degradation.

2.2.2 CIS nanocrystal synthesis

CIS nanocrystals were synthesized as previously described.¹¹⁻¹² Briefly, 5 mmol of CuCl (0.45 g) and 5 mmol of InCl₃ (1.11 g), 50 ml of degassed OLA and a magnetic stir bar are sealed in a 100-mL three-neck flask with septa, and an attached condenser-stopcock valve combination. The reaction flask is taken outside the glovebox and mounted on a conventional Schlenk line setup. The flask is purged of oxygen and water by pulling vacuum at 110 °C for 30 min, followed by N₂ bubbling at 110 °C for 5 min while stirring.

A 1M TBP:Se solution is separately prepared in the glovebox by dissolving 10 mmol of Se (0.79 g) in 10 ml TBP in a 25 ml vial under magnetic stirring. The resulting Se reactant solution is drawn into a syringe and taken outside the glovebox in preparation for injection into the reaction flask on the Schlenk line. At this point, the temperature of the reaction flask is raised to 240 °C at a heating rate of approximately 50°C/min. When the temperature in the flask reaches 180°C, the TBP:Se stock solution is injected into the flask. The reaction mixture is then maintained at 240°C for 10 minutes. The heating mantle is removed and the reaction is allowed to cool to room temperature. The contents of the reaction vessel and 10 ml of ethanol are mixed in a glass centrifuge tube, and the nanocrystal product is precipitated by centrifugation at 4000 rpm for 5 minutes. The supernatant is discarded. The nanocrystal product is redispersed in 5 mL of toluene and centrifuged at 4000 rpm for 5 minutes to remove the larger and poorly capped product. The supernatant is added to a new glass centrifuge tube and the precipitate is discarded. Ethanol is then slowly added to the nanocrystal dispersion until the mixture becomes slightly turbid. The mixture is centrifuged at 4000 rpm for 5 minutes to again precipitate

the nanocrystal product. The supernatant is discarded, and the solid product is redispersed in toluene to a final concentration of 20 mg/ml.

2.2.3 Materials characterization

Transmission electron microscopy (TEM) was performed using either a Phillips 208 TEM operated with 80 kV accelerating voltage or a JEOL 2010F TEM at 200 kV. TEM samples were prepared by drop casting from chloroform onto a 200 mesh nickel grid with a carbon film (Electron Microscopy Sciences). Energy dispersive X-ray spectroscopy (EDS) was carried out using an Oxford INCA EDS detector on the JEOL 2010F TEM.

Scanning electron microscopy (SEM) images were obtained for device-ready nanocrystal films using a Zeiss Supra 40 VP SEM operated at 10 keV accelerating voltage. Images were collected through the in-lens detector. Samples were grounded to the SEM base using a strip of copper tape to prevent charging of sample surface.

X-ray diffraction (XRD) was performed using a Bruker-Nonius D8 Advance θ – 2θ Powder Diffractometer equipped with a Bruker Sol-X Si(Li) solid-state detector and a rotating stage. Cu K $_{\alpha}$ ($\lambda = 1.54 \text{ \AA}$) radiation was used. XRD data was collected at 0.02 increments of 2θ at a scan rate of $12^{\circ}/\text{min}$ with a theta-theta goniometer and sample rotation of 15 RPM.

UV–vis–NIR absorbance spectroscopy was performed at room temperature using a Varian Cary 500 UV–vis–NIR spectrophotometer. Nanocrystals were dispersed in hexane in quartz cuvettes. Absorbance was also measured for thin, optically transparent nanocrystal films deposited by spray coating on a quartz substrate.

2.2.4 PV device fabrication and testing

Conductive back contacts (molybdenum, gold, or ITO) were deposited on soda lime glass (Delta Technologies, 25 mm x 25 mm x 1.1 mm polished float glass) or kapton (Dupont) using conventional vapor deposition techniques. Molybdenum and ITO were RF sputtered and gold was thermally evaporated. 20 mg/ml solutions of nanoparticles were prepared for the spray deposition. CIS nanocrystal layers were spray-coated with an airbrush (Iwata Eclipse HP-CS) operated at 50 psig of head pressure. CdS buffer layer was deposited by chemical bath deposition following procedures described by McCandless and Shafarman.¹⁵ Briefly, the device is preheated to 90°C by placing it directly on a heated hotplate; 1ml of an aqueous solution containing 3 mM CdSO₄, 0.53 M thiourea, and 8.1 M NH₃ is dropcast on the surface of the device and the reaction chamber is quickly sealed by placing an inverted petri dish directly above the substrate. The reaction is allowed to proceed for 2 minutes. At that stage, the substrate is removed and washed by running DI water over the surface. The film is dried by blowing clean air over the surface. i-ZnO/ITO top contacts were deposited by RF sputtering from targets of ZnO (99.9%, Lesker) in an atmosphere of 0.5% O₂ in Ar (99.95%, Praxair) or ITO (99.99% In₂O₃: SnO₂ 90:10, Lesker) in an Ar atmosphere (research grade, Praxair). The final active region of the device was 8 mm² (a 4 mm x 2 mm rectangle).

PV response was measured using a Keithley 2400 General Purpose Sourcemeter and a Xenon Lamp Solar Simulator (Newport) equipped with an AM1.5 filter. Incident photon conversion efficiency (IPCE) spectra were gathered using a home-built spectrophotometer with a lock-in amplifier (Stanford Research Systems, model SR830), a

monochromator (Newport Cornerstone 260 1/4M), and a Si photodiode calibrated by the manufacturer (Hamamatsu). IPCE was collected under ambient light. PV devices were stacked by placing the active areas directly on top of each other, and then connecting the stacked devices in parallel using conductive silver paint (SPI Supplies). There was less than 5% area offset between multiple stacked devices.

2.3 Results and Discussion

2.3.1 CIS nanocrystals

Figure 2.1 shows TEM, SEM and XRD data for the oleylamine-capped CIS nanocrystals. The nanocrystals are composed of chalcopyrite CIS with an average diameter of 12 ± 4 nm, and a slightly irregular, faceted shape. The atomic ratio of Cu:In:Se in the nanocrystals determined by EDS is nearly 1:1:2, with a tendency to be slightly Cu rich, with a Cu/(Cu+In) ratio of 52%. Using the approach reported here for nanocrystal synthesis, it has not been possible to vary the Cu:In ratio. The nanocrystals disperse in various organic solvents, including chloroform, hexane, toluene and acetone. Toluene was used as the dispersing solvent for the nanocrystal inks used to fabricate devices, as it provided the most uniform coatings of the solvents that were tested. An SEM image of a spray-deposited 300 nm thick nanocrystal film is shown in Figure 2.2c. The film has uniform thickness and is nearly free of drying cracks, which is crucial for obtaining functional PVs without electrical shorts. In practice, it is very difficult to completely eliminate drying cracks, and even the film in Figure 2.2c has some observable cracks. However, much thicker films were much more prone to cracking, and films thicker than about 800 nm tended to be electrically shorted due to significant cracking

during the drying of the films. Film uniformity is still one aspect of the device fabrication process that requires further optimization.

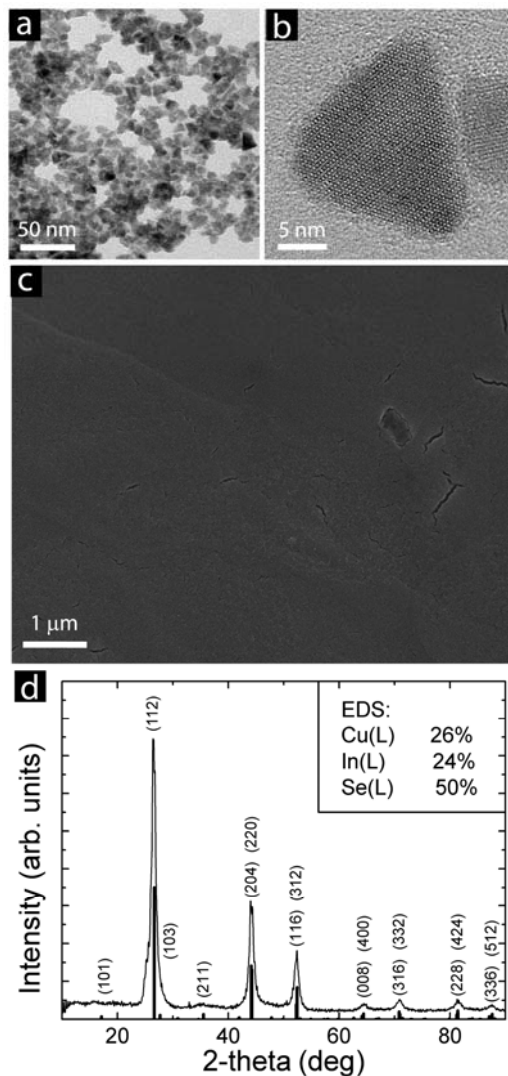


Figure 2.1. (a,b) TEM images of CIS nanocrystals; (c) an SEM image of a film of CIS nanocrystals spray-deposited from a toluene dispersion; (d) XRD pattern of CIS nanocrystals indexed to chalcopyrite CIS (PDF#97-006-8928). The inset in (d) is the average Cu, In and Se composition determined by EDS of a field of nanocrystals.

2.3.2 PV devices fabricated by spray-deposition of CIS nanocrystals.

Figure 2.2 shows a cross-sectional SEM image of a PV device made by spray-depositing a CIS nanocrystal layer. The device has a similar architecture as those with the highest reported efficiency for CIGS,³ consisting of layers of glass/Mo/CIS(nc)/CdS/ZnO/ITO. No high temperature annealing or selenization of this device was carried out. This particular device had a power conversion efficiency under AM 1.5 simulated sunlight of 1.18%.

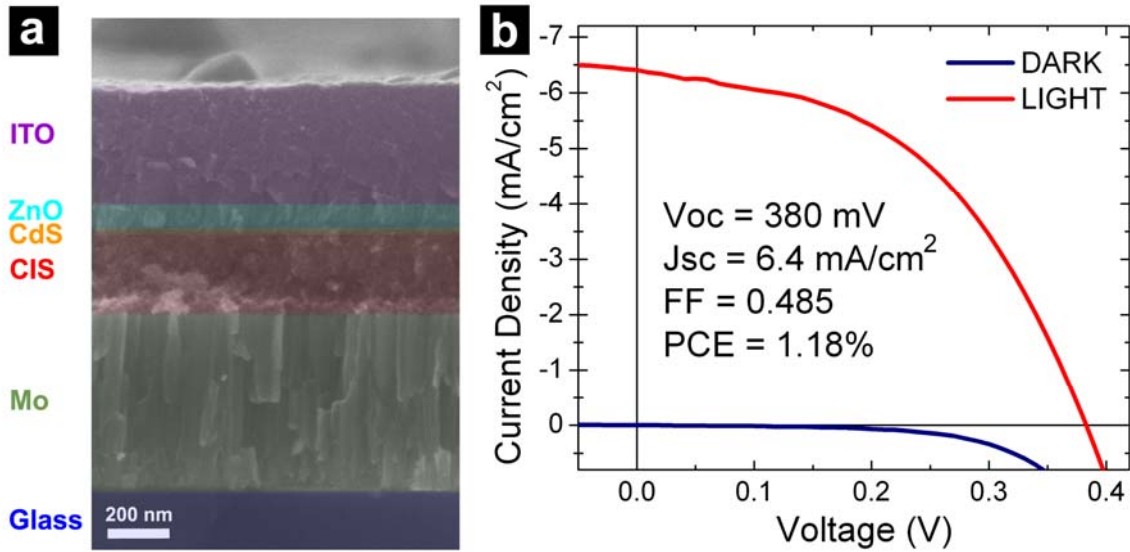


Figure 2.2. (a) SEM image of a cross-section of the PV device built using the conventional device architecture with spray coated CIS nanoparticle layer in place of vapor deposited CIS layer and (b) the I-V characteristics and power conversion efficiency of a typical PV device with this structure.

Since the absorber layers are not processed at high temperature, alternative substrates and contacts can be used, including transparent conductive ITO or mechanically flexible plastic. Figure 2.3 shows photographs of different kinds of PV devices that could be prepared by spray-depositing CIS nanocrystal absorber layers. The devices generally consist of a sandwiched construction of the p-type light-absorbing

nanocrystal layer interfaced with an n-type semiconductor (CdS, ZnO) positioned between two planar conducting contacts. The thin CdS layer (5-10 nm) also helps protect the CIS nanocrystal layer during sputtering of the window layer.

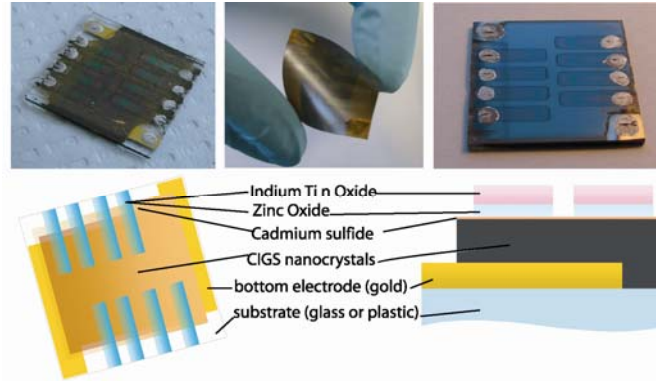


Figure 2.3. (Top) Photographs of PVs fabricated by spray depositing CIS nanocrystals on various substrates: (top left and right) glass and (top, middle) plastic (kapton). (Bottom) Illustration of the device layer structure as viewed from the top and from the side.

2.3.3 Replacement of the Mo back contact with Au

Conventional vapor-deposited CIGS PVs are fabricated on soda lime glass substrates with Mo back contacts because it can withstand the high selenization/annealing temperatures used to process the CIGS layer. The work function of Mo, however, is not well suited for the devices, as it creates a Schottky barrier with the CIS layer. During the selenization process, a thin MoSe₂ layer is created that provides ohmic contact to the CIGS layer, so this is not a problem.¹⁶ However, without annealing, the Schottky barrier between Mo and CIS significantly limits device performance.

Gold (Au) has a higher work function than Mo and should make a better back contact metal for the p-type CIS nanocrystal layer. Au is not used in conventional CIGS PVs because it cannot withstand the high temperature annealing conditions. We have

found that CIS nanocrystal PVs made with Au contacts on glass outperform those made with Mo contacts. Au contacts are also easy to deposit on plastic substrates for flexible devices. Figure 2.4 shows device characteristics of PV devices made from spray-deposited CIS nanocrystal layers on Au contacts on (2.4a) glass and (2.4b) plastic substrates.

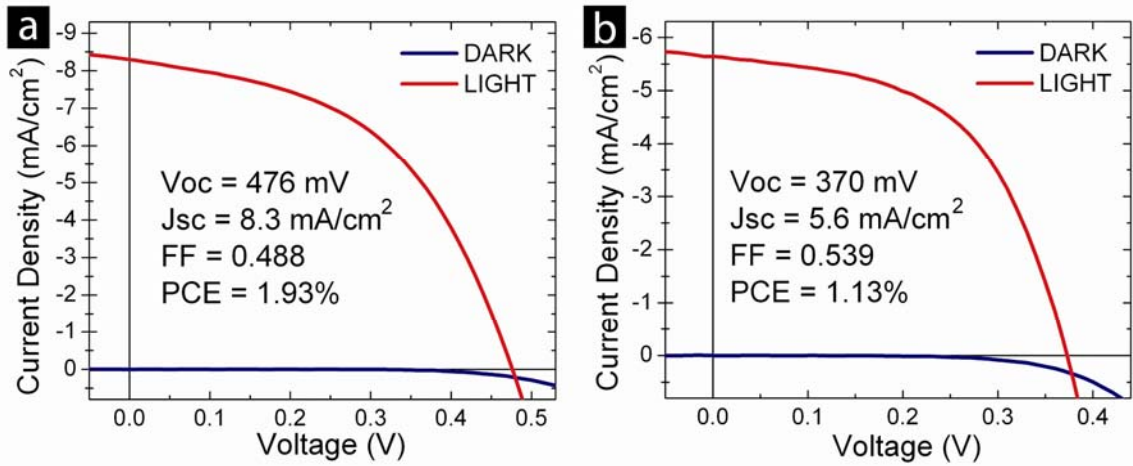


Figure 2.4. I-V characteristics of spray-deposited CIS nanocrystal PVs with gold back contacts on (a) soda lime glass and (b) plastic (kapton). The power conversion efficiencies (PCE) were measured under AM1.5 illumination.

2.3.4 Influence of CIS layer thickness on device efficiency

The relatively modest power conversion efficiency (up to 2% PCE under AM1.5 illumination) of the nanocrystal-based PVs is primarily related to the lower short circuit current (J_{sc}) compared to the conventional vapor-deposited devices. Vapor-deposited CIS layers are capable of producing J_{sc} in excess of 40 mA/cm²,^{2,23} whereas, we have not been able to achieve J_{sc} values greater than 10 mA/cm² from the CIS nanocrystal PVs. Interestingly, the nanocrystal PVs with the highest J_{sc} have been made with relatively thin absorber layers that are less than 200 nm thick—far too thin to absorb all of the incident

light. Incomplete absorption of the incident light leads to losses in the power conversion efficiency. Devices made with thicker nanocrystal layers absorb more light, but do not have improved efficiency. Figure 2.5 summarizes performance data for devices made with varying nanocrystal layer thickness, showing the trends in power conversion efficiency with nanocrystal layer thickness.

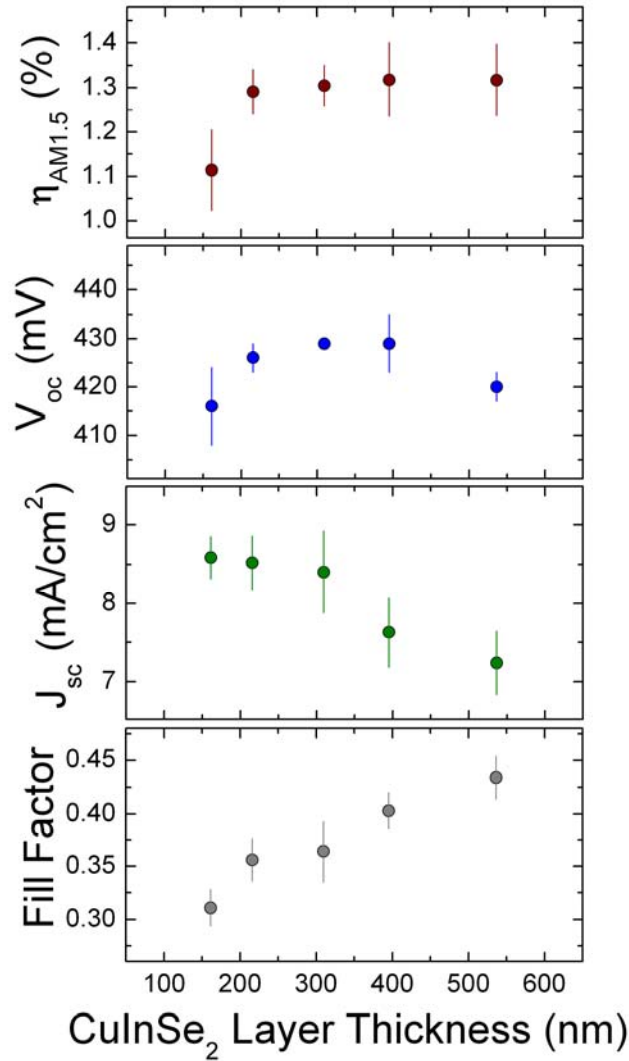


Figure 2.5. Device characteristics measured for PVs made with spray-deposited CIS nanocrystal layers of varying thickness. $\eta_{AM1.5}$ is the PCE under AM1.5 illumination, V_{oc} is the open circuit voltage, and J_{sc} is the short circuit current density.

Figure 2.6a shows the optical absorbance spectra for a 200 nm thick CIS nanocrystal film. The layer absorbs only a limited fraction of incident light, especially at the longer wavelengths near the band edge. It is also worth noting that the optical absorption of the nanocrystal layer is weaker than a dense CIS film due to the presence of the ligands—approximately 30% of the volume in the film is occupied by ligands, which only absorb very short wavelength blue and UV light. Devices made with thicker nanocrystal films absorb proportionally more light, but do not perform better. In fact, J_{sc} was found to decrease with increasing CIS film thickness, as shown in Figure 2.5. This means that the nanocrystal films have a high charge carrier trap density with significant electron-hole recombination that lead to losses in efficiency.

Figure 2.6b shows the external and internal quantum efficiencies of a CIS nanocrystal device as a function of photon wavelength. The external quantum efficiency (EQE)—also known as incident photon conversion efficiency (IPCE) spectra—are determined by measuring the short circuit current (at zero bias) when the device is illuminated with varying photon wavelength. The EQE are not equivalent to power conversion efficiencies, but nonetheless provide revealing data about internal losses due to electron-hole recombination. The EQE is lowest near the CIS optical gap due to low light absorption, but extends across all visible wavelengths, indicating that the devices are functioning via light absorption by the nanocrystals.

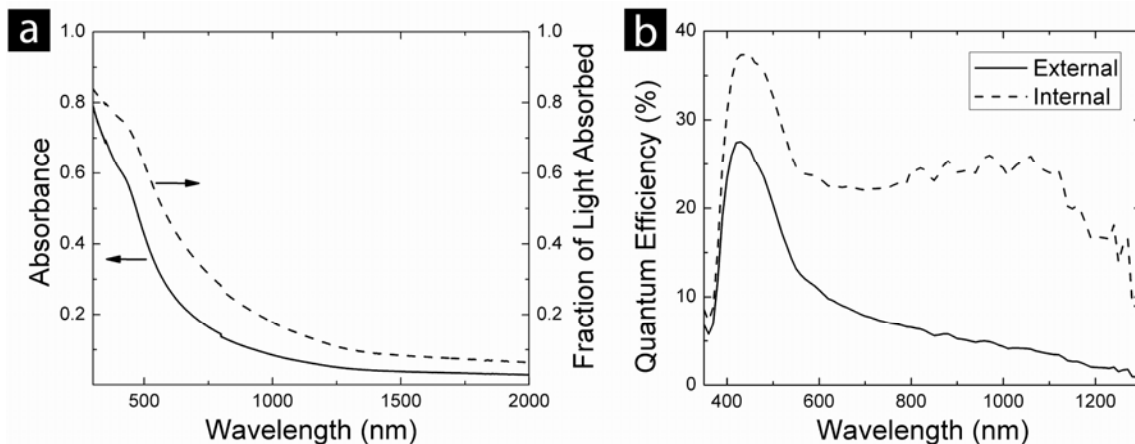


Figure 2.6. (a) UV-vis-NIR absorbance spectra of a 200 nm thick CIS nanoparticle film on a quartz substrate and the corresponding fraction of incident light that is absorbed. (b) External and internal quantum efficiency (EQE and IQE) of a PV device made with a spray-deposited CIS nanocrystal layer. EQE is determined from the incident photon conversion efficiency (IPCE) spectra, which is a measure of short circuit current as a function of light wavelength. The IQE is then determined from the EQE by accounting for the fraction of light that is absorbed by the CIS layer at each wavelength (i.e., the absorbance spectra). It should be noted that these IQE calculations do not account for additional absorption in the active layer that might occur due to internal reflections within the device, and the absorbance of light by CdS at wavelengths of 500 nm and less are also not accounted for in the IQE calculation.

Another way to examine the losses in the device due to electron-hole recombination is to calculate the internal quantum efficiency (IQE). The IQE is obtained by normalizing the EQE with the optical absorption in the nanocrystal layer and does not depend on how much light the layer absorbs. The devices made with thin nanocrystal layers had reasonably high values of IQE, of about 25% across the visible spectrum. The peak in IQE at about 450 nm is related to light absorption by the CdS buffer layer. Clearly, the PCE of the nanocrystal devices could be significantly improved if losses due to recombination could be reduced. Perhaps this could be accomplished by improving

capping ligand passivation of traps on the nanocrystal surfaces and by reducing the energy barrier to interparticle charge transport with thinner ligand layers.

2.3.5 Improved efficiency by device stacking

One other way to improve overall PCE, given the significant amount of recombination in the device is to stack multiple devices with thin absorber layers and transparent contacts to combine the efficiency of each device layer. Figure 2.7 shows the device characteristics of a spray-deposited CIS nanocrystal PV with ITO back contacts. Such a device configuration is not possible with conventional vapor deposition due to the high temperature annealing and selenization. The CIS nanocrystal layer in this device absorbs less than 50% of the AM1.5 solar spectrum (Figure 2.7b).

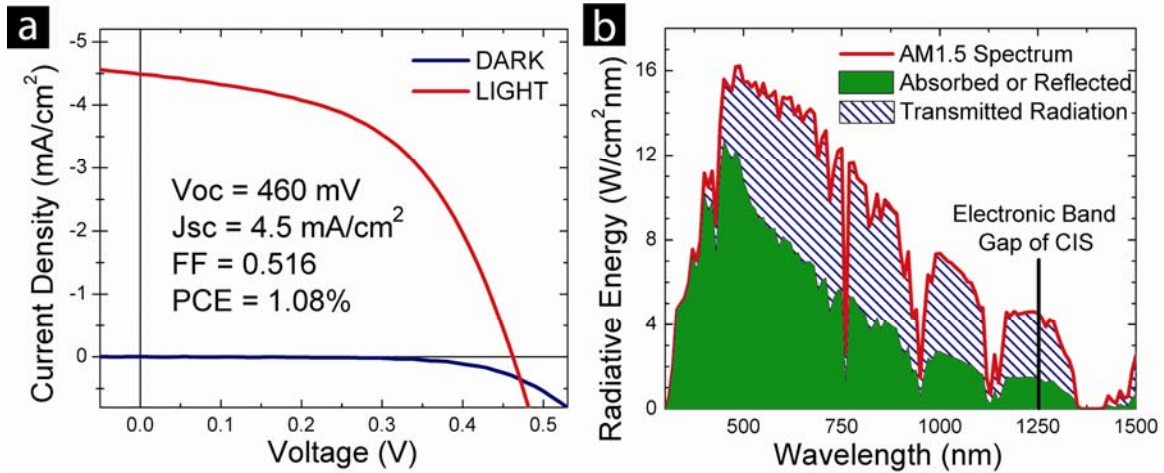


Figure 2.7. (a) I-V characteristics of a device prepared with a transparent ITO back contact, and (b) the fraction of the incident light absorbed and transmitted by the device on ITO determined from the UV-vis absorbance spectra of the device.

Figure 2.8 shows the device performance of stacked PV structures with two and three junctions compared to a single junction device. The stacked devices have enhanced J_{sc} . For example, the triple-stacked, spray-deposited CIS nanocrystal PV device had a 70% improvement in J_{sc} compared to a single junction device. However, in these particular devices, V_{oc} and the fill factor also decreased when the devices were stacked, reducing the gains in enhanced J_{sc} enough that the PCE did not increase. Nonetheless, stacked devices could be made that also exhibited higher PCE. Figure 2.9 shows a stacked PV device with significantly enhanced PCE compared to the single junction devices. This device was made by layering a semi-transparent device with ITO top and bottom contacts over a device with an ITO top contact and a Au bottom contact, which yielded a power conversion efficiency of 2.1% under AM 1.5 simulated sunlight. Table 2.1 summarizes the device parameters for the two different stacked PV structures. Combining the Au back contact junction with an ITO back contact junction resulted in 20% improvement in PCE over the single junction devices (Figure 2.9).

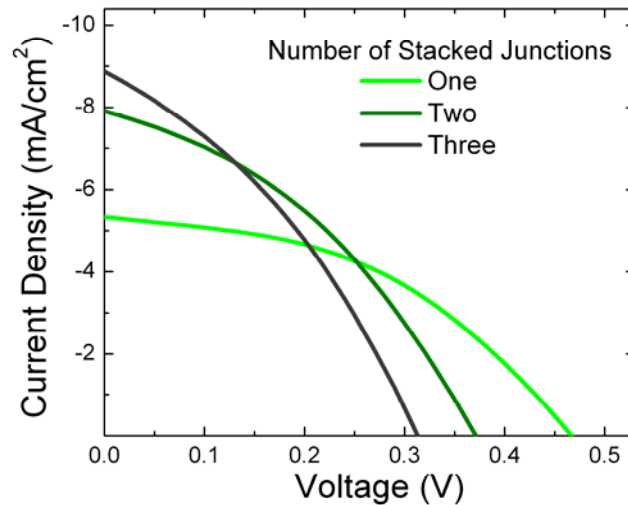


Figure 2.8. I-V characteristics of nearly transparent devices prepared with ITO back and top contacts placed in a stacked device configuration.

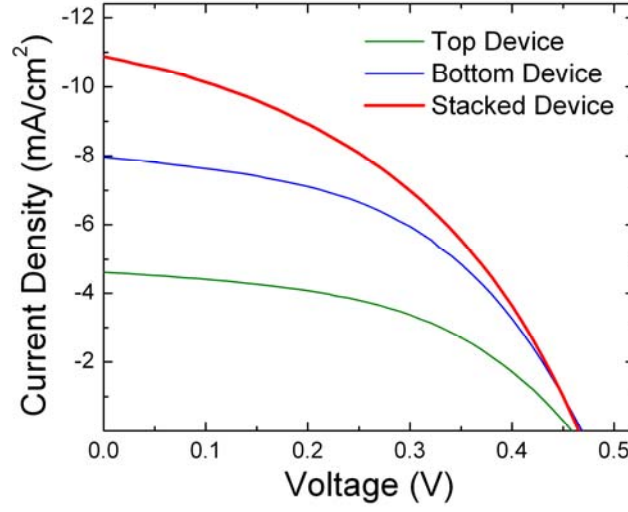


Figure 2.9. I-V characteristics of two CIS nanocrystal PVs measured independently and in a stacked configuration under AM1.5 illumination.

Table 2.1. Summary of device characteristics obtained from stacked junction spray-deposited CIS nanocrystal devices with transparent back contacts.

	Multiple Transparent Junctions			Highest Efficiency Stacked Device		
	One Junction	Two Junctions	Three Junctions	Bottom Device	Top Device	Stacked Device
$\eta_{AM1.5}$	1.1%	1.11%	0.97%	1.79%	1.01%	2.10%
J_{sc} (mA/cm ²)	5.34	7.907	8.87	7.96	4.62	10.88
V_{oc} (mV)	467	371	349	468	458	465
Fill Factor	0.442	0.379	0.349	0.479	0.478	0.414

The reason that all of the gains in J_{sc} have not translated directly into higher device efficiency is that the ITO contacts have suffered from a relatively low shunt resistance. Figure 2.10 shows a comparison of the dark I-V characteristics of CIS nanocrystal devices prepared with Au and ITO back contacts. The series resistance (R_s)

and shunt resistance (R_{sh}) of the devices were estimated by fitting the data to a diode equation,

$$I = J_0 A \left(e^{\frac{V - IR_s}{nkT}} + \frac{V - IR_s}{J_0 A R_{sh}} - 1 \right). \quad (2.1)$$

A is the area, J_0 is the saturation current density under reverse bias, and n is the ideality factor of the device, with k and T representing Boltzmann's constant and the temperature. Devices made with Au back contacts have significantly higher shunt resistance than the devices with ITO back contacts. Lower shunt resistance leads to reduced V_{oc} and FF and power conversion efficiency and must be improved in order to realize the full benefit of stacking the semi-transparent PVs. The stacked device structure used in Figure 2.9 is an example of a structure in which the use of lower performance ITO contacts is minimized by using a Au bottom contact, which also provides a reflective back contact to help increase the total amount of light absorption by the device.

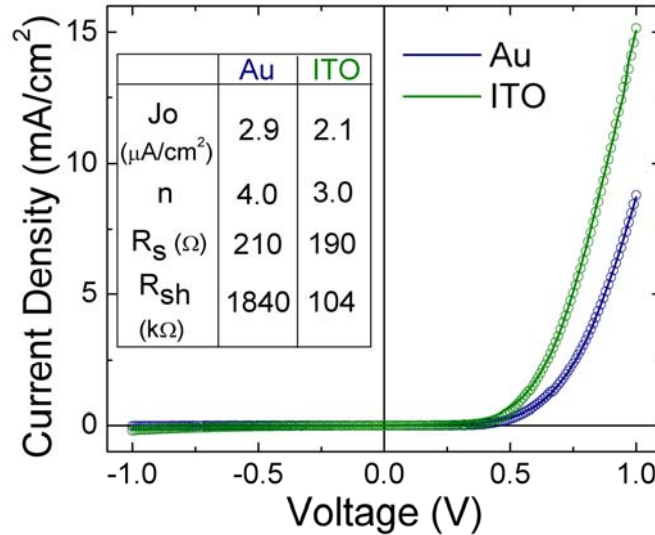


Figure 2.10. I-V characteristics of typical diodes used for the stacked structure devices that were prepared on Au and ITO back contacts. Measured data (open circles) were modeled (solid lines) using Eqn (2.1). The best fit of Eqn (2.1) to the data gives the diode parameters tabulated in the inset.

2.4 Conclusions

PV devices with reproducible and reliable power output were fabricated by spray-coating CIS nanocrystals without post-deposition annealing. Layered Au/CIS/CdS/ZnO/ITO PV devices exhibited power conversion efficiencies of up to 1.9% for single-junction devices and 2.1% for stacked-junction devices under AM 1.5 illumination. The device efficiency still requires significant improvement; however, it is similar to that of other nanocrystal devices that have been fabricated without post-deposition high temperature annealing. For example, Cd- and Pb-containing nanocrystal devices have exhibited efficiencies as high as 3.6%,¹⁷⁻²¹ and Cu₂S or Cu(Zn,Sn)S₂ systems have demonstrated efficiencies up to 1.5%.²²⁻²⁴ Nanocrystal-based devices in general have suffered to date from low J_{sc} . One approach to improving J_{sc} is to perform a post-deposition high temperature anneal to sinter the films and reduce the grain boundary density in the film, as Hillhouse and Agrawal have demonstrated for CuIn_{1-x}Ga_x(S_{1-y}Se_y)₂ PVs, in which they have achieved power conversion efficiency of more than 10%.¹³⁻¹⁴ Stacking single-junction nanocrystal devices provides a potential route for improved light harvesting and increased J_{sc} for significantly improved power conversion efficiency without the need for high temperature annealing.

A nanocrystal ink that could be used to fabricate high efficiency PVs without the need for high temperature processing would change the way PVs are made. New contact and substrate combinations could be used, with high throughput roll-to-roll processing on lightweight, flexible plastic substrates. At the moment, however, nanocrystal-based PVs require higher efficiency. This means that a better understanding of how to passivate defects and traps in the nanocrystal layers and at materials interfaces in the devices,

without resorting to high temperature sintering, is needed and remains an ongoing topic of research. Next chapter discusses the limitations of nanocrystal based devices and provides a numerical measurements of the limitations in these devices.

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Chapter 3: Thickness-Limited Performance of CuInSe₂ Nanocrystal Photovoltaic Devices*

3.1 Introduction

Various new approaches are being examined to produce “third generation” photovoltaic devices (PVs) with very low cost and high efficiency.¹⁻³ There is interest in enhancing performance using nanostructured materials via new physical effects, such as multi-exciton generation (MEG)⁴ and intermediate band absorption,⁵ as well as lowering manufacturing costs by using new materials that can be deposited without the need for high temperature and vacuum processing.⁶ Photovoltaics made of organics (OPVs) are printable, do not require high temperature processing, and have demonstrated efficiencies of 7.4% for solution processed devices.⁷ However, the most efficient devices have so far required relatively expensive specialty chemicals to achieve high efficiencies. Furthermore, achieving adequate photostability remains a major challenge with these materials. An alternative to organic materials, which can still be printed and require only moderate processing conditions, are dispersions, or inks, of inorganic nanocrystals. With this approach, inorganic materials with proven and stable performance can be deposited using by mild deposition processes typically only suitable for organic materials and not crystalline semiconductors.⁸ Cd and Pb based nanocrystal PV devices⁹⁻¹³ have exhibited power conversion efficiencies as high as 5.1%.¹⁴ However, the use of Cd and Pb is not

* Large portions of this chapter were reproduced with permission from: V. A. Akhavan, M. G. Panthani, B. W. Goodfellow, D. K. Reid and B. A. Korgel, “Thickness-Limited Performance of CuInSe₂ Nanocrystal Photovoltaic Devices,” *Energy Express*, 18(S3), A411–A420 (2010). Copyright 2010 Optical Society of America.

very desirable from an environmental perspective due to their toxicity. Other more environmentally-friendly semiconductor nanocrystals, such as $\text{Cu}(\text{In}_{1-x}\text{Ga}_x)\text{Se}_2$,¹⁵ $\text{Cu}_2\text{ZnSnS}_4$ ¹⁶⁻¹⁷ or Cu_2S ¹⁸ have also been used to fabricate PVs, but with slightly more moderate efficiencies of up to 1.6% to date. These multicomponent semiconductors are difficult and expensive to prepare through conventional vapor deposition techniques. Nanocrystal solution processing provides an inexpensive and simple processing route that could be scaled to larger production lines and transferred to flexible and light-weight plastic substrates. For commercialization, the device efficiency must be improved by about a factor of 5 to 8.

The factors that limit nanocrystal-based PV device efficiency are still relatively unexplored and to date, the highest efficiency nanocrystal PVs have been made by time-consuming empirical optimization. The devices consist of several layers of different materials and the quality of each layer and the interfaces critically impact the performance of the devices. Here, we examine the factors related to the nanocrystal layer and the semiconductor heterojunction that limit the efficiency of CuInSe_2 nanocrystal-based PVs.

Previous chapter demonstrated CuInSe_2 nanocrystal synthesis and the implementation of CuInSe_2 nanocrystals into functioning PVs.¹⁵ This chapter demonstrates CuInSe_2 nanocrystal device efficiency reaching 3.1% without the need for high temperature annealing. We report these results here, and examine the factors that are limiting device efficiency.

3.2. Experimental

3.2.1 Nanocrystal inks

CuInSe₂ nanocrystals were synthesized by arrested precipitation using a modification of previously reported procedures.¹⁵ Oleylamine (OLA; >70%), tributylphosphine (TBP; 97%), copper(I) chloride (CuCl; 99.995%), indium(III) chloride (InCl₃; anhydrous 99.99%) and selenium (Se; 99.99%) were purchased from Aldrich Chemical Co. and used as received.

5 mmol of CuCl, 5 mmol of InCl₃ was combined with 50 ml of OLA in a three neck flask in a nitrogen-filled glovebox. The flask was sealed by a condenser-stop cock setup and two septa; the flask was brought outside and mounted on a Schlenk line. The reaction mixture was heated up to 110 °C, degassed for 10 minutes by pulling vacuum on the vessel and was purged with clean nitrogen for 5 minutes. While maintaining the nitrogen environment, the reaction vessel was heated to 180 °C and 10 ml solution of 1 M Se in TBP (0.79 g Se powder and 10 ml TBP) was injected into the reaction vessel. The reaction mixture temperature was raised to 240 °C as quickly as possible and the reaction was allowed to proceed for 10 minutes. The heating mantle was removed and the reaction was cooled slowly to room temperature.

After cooling, the reaction mixture was transferred to a glass centrifuge tube. 10 ml of ethanol was added to the centrifuge tube, and the mixture was centrifuged at 4500 RPM for 10 minutes. The supernatant was discarded, and the solid precipitate was dissolved in 10 ml of toluene. The new solution was centrifuged at 4500 RPM for 10 minutes to remove larger and poorly capped nanocrystals. The supernatant was transferred to a new glass centrifuge tube, and the solid precipitate discarded. Ethanol

was added drop-wise to the particle solution until a turbid mixture was achieved. The reaction was centrifuged again at 4500 RPM for 10 minutes. The supernatant was discarded, and the precipitate dissolved in toluene to achieve a 20 mg/ml solution.

3.2.2 Materials characterization

TEM was performed on a Phillips 208 operated at 80 kV accelerating voltage or a JEOL 2010F TEM at 200 kV accelerating voltage. TEM samples were prepared on a 200 mesh nickel grid (Electron Microscopy Sciences) by dropcasting a dilute solution of nanocrystals in chloroform. EDS was carried out using an Oxford INCA EDS detector mounted on the JEOL TEM or a Bruker Quantax 200 detector mounted on a Hitachi S-5500 STEM. SEM images were collected using a Zeiss Supra 40 VP SEM operated at 10 kV accelerating voltage. Images were collected through the in-lens detector. SEM samples were prepared by depositing a thin layer of the nanocrystals on a conductive surface. XRD data was collected on a Bruker-Nonius D8 advance θ - 2θ powder diffractometer equipped with a Bruker Sol-X Si(Li) solid state detector and a rotating stage. 1.54 Å radiation (Cu K $_{\alpha}$) was used to collect at 0.02 increments of 2θ at a scan rate of 12 °/min while the sample was rotating at 15 RPM. XRD samples were prepared by depositing a relatively thick ($\approx 10 \mu\text{m}$) film of nanocrystals on a glass substrate. UV-vis-NIR absorbance spectra were measured using a Varian Cary 500 spectrophotometer.

3.2.3 PV device fabrication

PV devices were fabricated with a layered CuInSe₂/CdS/i-ZnO structure, similar to reported by Contraras [19]. Sodalime glass substrates (Delta Technology) were cleaned by sonication in an acetone/isopropanol mixture, followed by rinse with DI water, and drying under nitrogen. Back contact layers of 5 nm thick Cr (99.999%, Lesker) adhesion

layer with 60 nm of Au (99.95%, Lesker) were deposited by thermal evaporation. Nanocrystal dispersions were deposited on the Au back contacts by spray deposition of dispersions in toluene with concentrations of 20 mg/ml nanocrystals using a commercial spray gun (Iwata Eclipse HP-CS) operated at 50 psig head pressure. The nanocrystal layer was obtained by profilometry or from SEM images of cross-sectioned devices. Following nanocrystal deposition, CdS layer was deposited with the method reported by McCandless and Shafarman [20]. Then, 50 nm of ZnO was AC sputtered (99.9% Lesker, 5 ppm O₂ in Ar sputtering gas) followed by another 600 nm layer of sputtered ITO (99.99% Lesker, UHP Ar sputtering gas). The final active area of the device is 8 mm², a 4 mm by 2 mm rectangle. Completed devices were placed in a vacuum oven at 200 °C for up to 40 minutes to improve the device performance.

Mott-Schottky measurements were performed on PVs with slightly different structures. 300 nm of AC sputtered ITO was used as substrate to deposit CuInSe₂ nanocrystal films as described above. Top contact was a 40 nm layer of Al (Lesker, 99.99%) thermally evaporated from a tungsten boat. The active device area was 8 mm².

3.2.4 PV device testing

Current-potential (I-V) characteristics were collected using a Keithley 2400 general purpose sourcemeter and a Xenon lamp solar simulator (Newport) equipped with an AM1.5 optical filter. Intensity of the light source was calibrated using a NIST calibrated Si photodiode (Hamamatsu, S1787-08). Different fractions of solar spectrum were generated by placing a colored glass, cutoff filters (Newport) directly in the path of light beam emanating from the solar simulator. Incident photon-to-electron conversion efficiency (IPCE) measurements were performed at zero bias between 300 and 1100 nm

in 10 nm steps using an in-house fabricated spectrophotometer. Monochromatic light was generated using a commercial monochromator (Newport Cornerstone 260 1/4M). Generated light was chopped at 213 Hz and was focused to a spot size of 1 mm in diameter on the active region. The response of the device was recorded using a lock-in-amplifier (Stanford Research Systems, model SR830). The light intensity was calibrated using calibrated photodiodes of silicon (Hamamatsu) and germanium (Judson).

Impedance characteristics was measured by applying a 50 mV A-C waveform at frequencies between 0.1 Hz and 10^7 Hz with 5 steps per decade, using a Solartron 1260A Frequency Response Analyzer coupled with a Solartron 1296 Dielectric Interface.

3.3 Results and Discussion

3.3.1 CuInSe₂ nanocrystal inks

Figure 3.1 shows TEM images and XRD data for the CuInSe₂ nanocrystals used to fabricate the PV devices. The nanocrystals are crystalline, with irregular, faceted shape and an average diameter of $14 \text{ nm} \pm 4 \text{ nm}$. XRD (Figure 3.1C) and EDS confirmed that the nanocrystals have chalcopyrite crystal structure with stoichiometric (1:1:2) Cu:In:Se composition. Figure 3.1 also shows an illustration of the chalcopyrite unit cell of CuInSe₂. The nanocrystals are coated with a monolayer of oleylamine, which stabilizes their size and provides dispersibility in organic solvents.

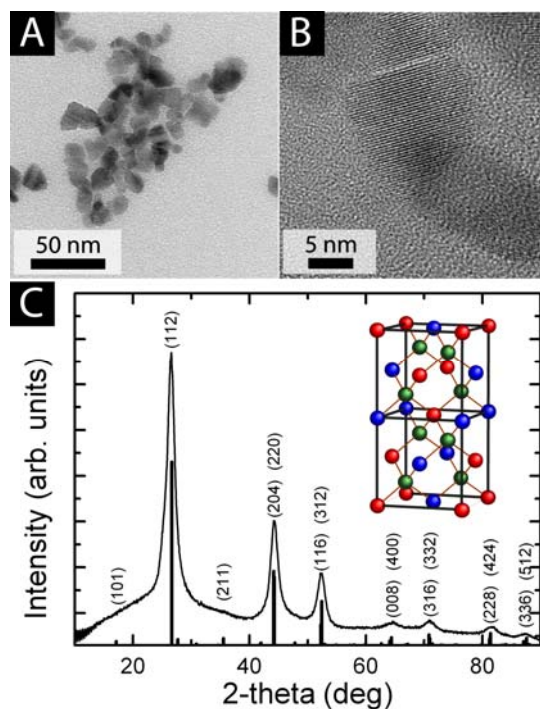


Figure 3.1. (A, B) TEM images and (C) XRD of the CuInSe_2 nanocrystals. The diffraction peaks in (C) are indexed to chalcopyrite CuInSe_2 (PDF#97-006-8928). The inset shows the chalcopyrite unit cell of CuInSe_2 : red, blue and green spheres correspond to copper, indium and selenium atoms, respectively.

3.3.2 PV device fabrication

PV devices were fabricated by spray-coating the CuInSe_2 nanocrystal ink onto Au back contacts on glass substrates. Nanocrystal films with uniform thickness with few pinholes or cracks are obtained using this method. Devices have been made using this approach with power conversion efficiencies under AM1.5 illumination of up to 3.1%. Figure 3.2 shows the dark and light I-V curves for the device with highest power conversion efficiency (PCE).

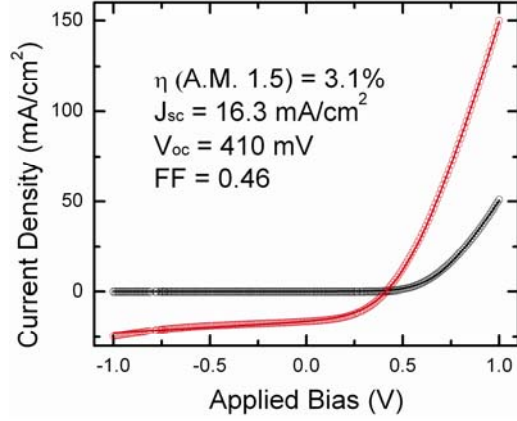


Figure 3.2. I-V characteristics of a device with power conversion efficiency of 3.1% under AM1.5 illumination. Dark conditions (black) and under AM1.5 irradiation (red). The device parameters are obtained by a best fit of Eqn (3.1) (solid lines) to the data (\circ). The parameters from the best fit are listed in table 3.1.

3.3.3 Diode behavior in the dark and light

The device in Figure 3.2 exhibits a “crossover” between the dark and the light I-V curves at forward bias, which is commonly observed in our devices. This crossover is undesirable as it leads to a decrease in device efficiency, and ideally should be prevented. The reason for this crossover can be deduced by modeling the device current density, J , based on a single junction diode model:

$$J = J_0 \left(e^{\frac{V - JAR_s}{nkT}} + \frac{V - JAR_s}{J_0 AR_{sh}} - 1 \right) - J_{ph} \quad (3.1)$$

In Eqn (3.1), J_0 is the reverse bias saturation current density, A is the device area, n is the ideality factor of the diode, R_s is the series resistance of the diode, R_{sh} is the shunt resistance of the diode, J_{ph} is the photogenerated current density, k is Boltzmann’s constant and T is temperature. Table 3.1 lists the device parameters obtained by fitting Eqn (3.1) to the device data in Figure 3.2. The large value of n , greater than 3, suggests that the devices are dominated by recombination current and illumination with light

increases the non-ideality of the diode. R_s and R_{sh} both decrease under illumination and J_0 increases by two orders of magnitude, indicating that the crossover is an outcome of photoconductivity of the materials in the device—mostly likely the CdS layer (see discussion in next paragraph). A reduction in R_s is desirable, as it lowers the barrier for current extraction, but reduced R_{sh} and increased J_0 are undesirable and result from higher recombination within the device.

Table 3.1. Diode performance parameters for the highest efficiency PVs.

	Dark	AM1.5 illumination
J_0 ($\mu\text{A}/\text{cm}^2$)	3.2	200
n	3.1	3.8
R_s (Ω)	57	29
R_{sh} ($\text{k}\Omega$)	1300	2.0
J_{ph} (mA/cm^2)	---	16.5

The origin of the photoconductivity effect leading to the crossover of the light and dark curves in the devices discussed above was examined by shining light on the device with different ranges of wavelengths. The CuInSe₂ nanocrystals have a band gap of about 1 eV, corresponding to a wavelength of 1236 nm. ZnO and CdS have much wider band gaps of 3.3 eV and 2.4 eV, corresponding to wavelengths of 375 nm and 515 nm, respectively. Figure 3.3A shows the I-V response of the device when it was illuminated with light with the high energy photons filtered out, as shown in Figure 3.3B.

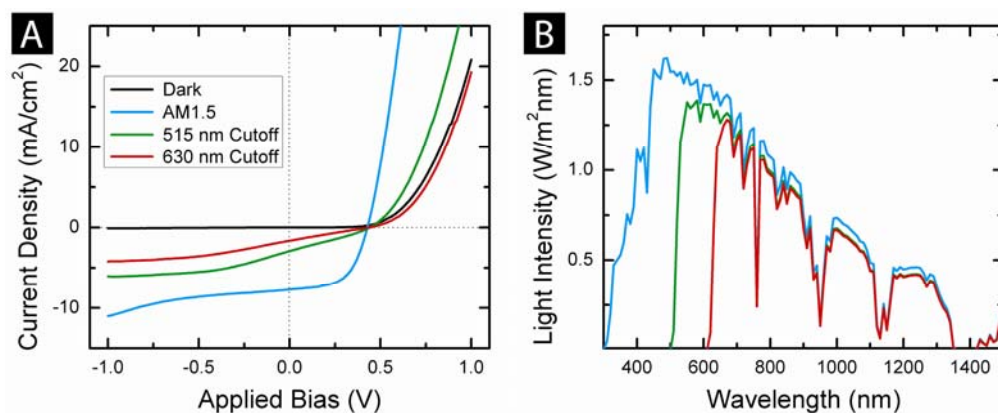
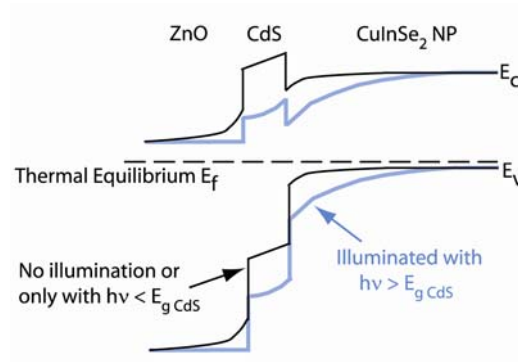


Figure 3.3. (A) I-V measurements of a CuInSe₂ nanocrystal PV device with a crossover between the light and the dark curves. Using light with wavelength higher than 515 nm, the crossover is still present. By using only low energy photons above 630 nm wavelength, however, the cross over between the dark and light curves is eliminated. (B) Spectra of light used for each illuminated measurement.

As shown in Figure 3.3A, the amount of crossover between the light and dark curves decreased when the shorter wavelength light was filtered, and it was completely eliminated when the illumination had wavelengths larger than the absorption edge of the CdS (515 nm) layer. Similarly, the shunt current in the reverse bias is reduced as longer wavelength light is used. These data show that it is the CdS buffer layer that leads to the high leakage current under illumination. .

Elimination of the shorter wavelength light and higher series resistance also significantly changed the fill factor of the device. The devices performed well under AM1.5 illumination, with a fill factor of 0.56. With a 515 nm cutoff filter, the fill factor decreased to 0.29, and with a 630 nm cutoff filter, it decreased to 0.24. Low fill factors in vapor-deposited CuInSe₂²¹ have been attributed to type-I band alignment between the CuInSe₂ and CdS layers. Scheme 3.1 shows the expected band alignment at the CuInSe₂/CdS/ZnO heterojunction.²² The CuInSe₂ nanocrystals are p-type, and there is

expected to be a “spike” in the conduction band alignment with the CdS buffer layer that creates a barrier to electron extraction under forward bias. The CdS buffer layer has a significant concentration of low energy donors that lead to its n-type behavior. There are additional deep electron traps, however, that reduce the concentration of mobile carriers present in the n-type CdS layer. When excitons are generated in the CdS layer, the deep traps are compensated by “photo-doping”,²³ which increases the number of mobile carriers, reduces the barrier to electron transport across the CdS layer and leads to an increased junction conductance (Scheme 3.1).^{21,24} Increased conductance is the reason for the observed crossover of the dark and light I-V curves. Additionally, as the concentration of mobile carriers in the CdS layer is increased, the Schottky barrier between the n-type CdS layer and the Au back contact is reduced, that can lead to higher leakage current through pinholes and cracks in the nanocrystal film when illuminated.



Scheme 3.1. Band alignment of CuInSe₂/CdS/ZnO heterojunction with or without the photo-doping of the CdS buffer layer. Modified from Poduv, *et. al.* [2]

3.3.4 Device performance limitation

Device efficiencies of 3% are too low for commercialization and need to be improved.²⁵ The highest efficiency devices are actually composed of relatively thin

nanocrystal layers that are only about 150 nm thick. We have found that increasing the nanocrystal layer thickness enhances light absorption but it does not improve device efficiency. Figure 3.4 shows I-V characteristics of devices made with nanocrystal films of increasing thickness. J_{sc} actually decreased when the nanocrystal films were made thicker, even though more electrons and holes are being photogenerated. This indicates that the photogenerated carriers cannot be extracted from the nanocrystal layer unless they are relatively close to the junctions.

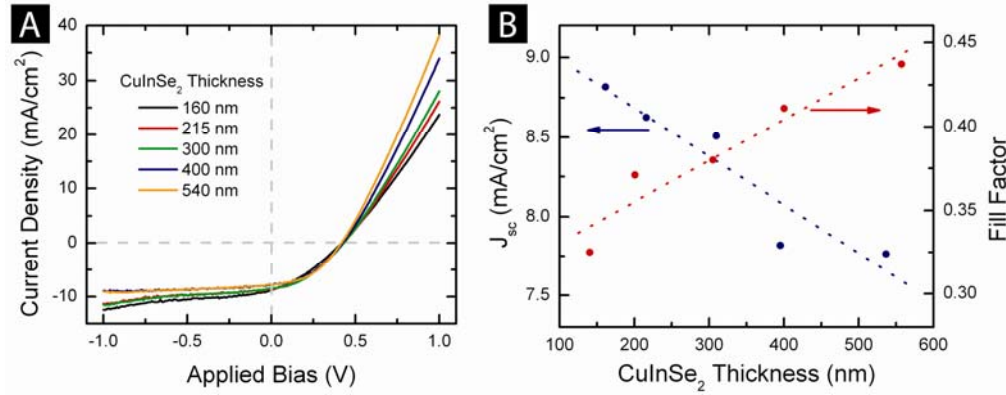


Figure 3.4. (A) I-V measurements of devices with varying thickness of spray deposited CuInSe₂ nanocrystal film and (B) calculated device parameters associated with these devices.

Measurements of the incident photon-to-electron conversion efficiency (IPCE) provide additional insight into how well the devices are performing and what the limiting factors are. In IPCE measurements, the short circuit current is measured as a function of the wavelength of the incident illumination. Figure 3.5A shows IPCE measurements for devices with varying nanocrystal layer thickness. The IPCE data is essentially an external quantum efficiency (at zero bias) that does not account for how much light is absorbed by the device—it is a measure of charge carriers extracted based on the number of photons that are illuminating the device. Another useful quantity is the internal

quantum efficiency, which provides an accounting of the photon absorption and tells what fraction of the photogenerated carriers are actually extracted from the device.

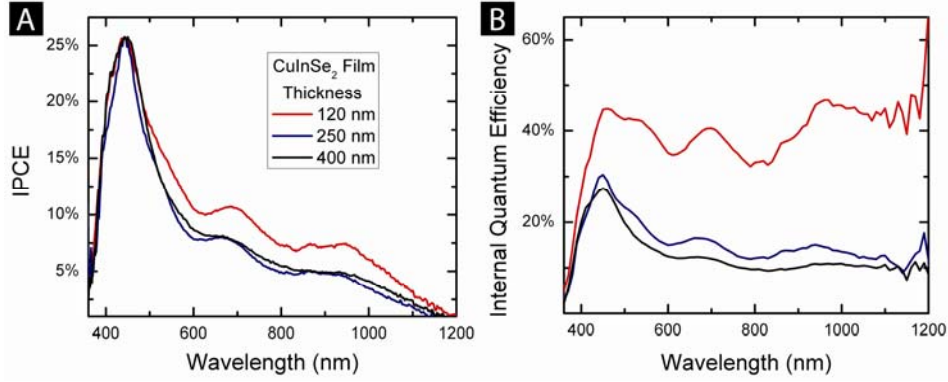


Figure 3.5. (A) IPCE measurements of a set of devices with different thicknesses of the CuInSe₂ nanocrystal film thickness shows similar trend between the different thicknesses. (B) Internal quantum efficiency data of the same devices reveals how thinner devices extract photogenerated carriers at a better efficiency.

The internal quantum efficiency of the devices, $IQE(\lambda)$, is the ratio of the wavelength-dependent IPCE, $IPCE(\lambda)$, to the fraction of the incident light at that wavelength that is absorbed by the CuInSe₂ nanocrystal films, $f(\lambda)$. $f(\lambda)$ is determined from the transmittance of the top window layer, $T_{top}(\lambda)$; the transmittance of the CuInSe₂ nanocrystals layer, $T_l(\lambda)$; and the reflectivity of the back contact, $R_{BC}(\lambda)$.

$$f(\lambda) \approx T_{top}(\lambda) \left[1 - T_l(\lambda)^2 R_{BC}(\lambda) \right] \quad (3.2)$$

It should be noted that this estimate of the $IQE(\lambda)$ does not account for internal reflection or optical interference effects that may also contribute to $f(\lambda)$ and represents an upper bound. Figure 3.5B shows the device IQE(%) for devices with different nanocrystal layer thickness. Consistent with the reduced J_{sc} for devices with thicker nanocrystal films, the thinner devices have much higher IQE, indicating that they are

much better at extracting photogenerated carriers, across a wide range of wavelength, than the thicker devices.

The higher IQE and more efficient device performance of the thinner devices is also enhanced by light reflection from the back contact. Especially, the thinner films benefit from a “second pass” of light reflected off the back contact. This is evident in the IPCE measurements at longer wavelengths (600 nm to 1200 nm) where only a very small fraction of the incident light is absorbed by the thinner layers on the first pass. As the films get thicker, a large fraction of the incident photons are absorbed deeper in the nanocrystals layer and the resulting photogenerated carriers are unable to be efficiently extracted. This data also indicates that the photogenerated carriers can only be extracted efficiently when they are generated close to the CuInSe₂/CdS/ZnO heterojunction.

3.3.5 Impedance spectroscopy

The thickness of the active region in the nanocrystal layer in the device was determined by measuring the impedance of the devices. Figure 3.6C shows typical impedance data on a CuInSe₂ nanocrystal PV device with slightly modified structure. The device geometry (shown in Figure 3.6A) was devised to ensure that carrier depletion was limited to the spray deposited CuInSe₂ film. The circuit model shown in Figure 3.6B was found to provide the best fit to the impedance data. The capacitance of the space charge region C_{sc} , was extracted to determine the majority carrier density and an effective depletion width in the nanocrystal layer using a Mott-Schottky analysis. C_{sc} is related to the doping level N_A , and applied voltage V :

$$\frac{1}{C_{sc}^2} = \left(\frac{2}{qN_A\epsilon_s\epsilon_0A^2} \right) \left(V - V_{bi} - \frac{kT}{q} \right) \quad (3.3)$$

In Eqn (3.3), V_{bi} is the built-in voltage of the junction, q is the elementary charge of an electron, ϵ_0 is the vacuum permittivity and ϵ_s is the relative permittivity of CuInSe₂ (≈ 10). Figure 3.6D shows C_{sc}^{-2} plotted against V . Values of N_A and V_{bi} were determined by fitting Eqn (3.3) to the data. The depletion layer width can be estimated from the relation:

$$V_{bi} = \frac{q}{2\epsilon_s\epsilon_0} [N_A x_p^2 + N_D x_n^2] \quad (3.4)$$

N_A and N_D are acceptor and donor concentrations in the p-type and n-type layers, respectively, and x_p and x_n are the depletion layer widths of the p-type and n-type layers, respectively. With the device design shown in Figure 3.6A, depletion occurs only in the p-type nanocrystal layer, and Eqn (3.4) simplifies to

$$V_{bi} = \frac{qN_A x_p^2}{2\epsilon_s\epsilon_0} \quad (3.5)$$

In a typical device the depletion region thickness was found to be 55 nm in the dark. When the device was illuminated, the depletion region thickness was found to decrease to 45 nm (under AM1.5 illumination). The change in doping level in the CdS layer under light leads to a noticeable change in the device properties, as discussed above. Further work is underway to gain a more detailed understand about the band alignment between layers in the nanocrystal devices.

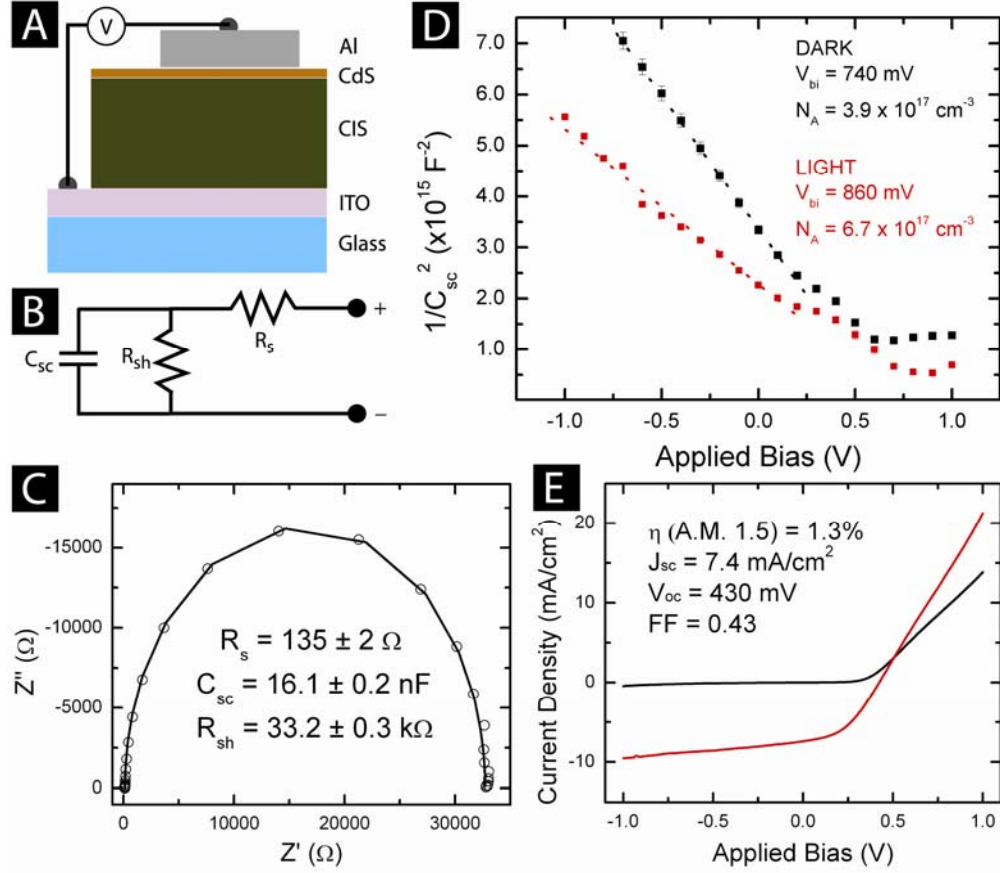


Figure 3.6. (A) Device architecture used for C-V measurements consists of a simplified junction. (B) One diode model considered for this type of junction to analyze the impedance data. (C) Sample Nyquist plot illustrating the response of the junction at a certain bias; inset provides the parameters gathered from the model fit (solid line) for the equivalent circuit to the raw data (marked by \circ). (D) Linear plot of inverse square capacitance of the junction versus applied voltage across the junction, inset provides the gathered parameters based on Mott-Schottky approximation. Area of this device was isolated to 8 mm^2 . (E) I-V characteristics of this junction show that it shows a very similar response to the more complex conventional devices, inset lists the device parameters.

3.4 Conclusion

Power conversion efficiencies above 3% under AM1.5 are demonstrated for ambient processed CuInSe₂ nanocrystal-based PVs. The extraction of photogenerated carriers from deep within the CuInSe₂ nanocrystal film remains a major challenge. The high

concentration of crystal interfaces leads to high recombination. A Mott-Schottky analysis of the space-charge capacitance in the device revealed that the active region of the device is only about 50 nm thick, which is consistent with IPCE and IQE measurements on devices with varying nanocrystal film thickness. Future efforts must focus on increasing the thickness of the space charge region to extract carriers deeper in the nanocrystal layer in order to improve device efficiency. Next chapter overviews the attempts to increase the J_{sc} of nanocrystal based devices through increasing the space charge region in the nanocrystal films. Synthetic procedures or chemical treatment routes were investigated to avoid high temperature selenization of the films.

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Chapter 4: Improved Device Performance with Modification to Synthetic Chemistry and Low-Temperature Treatment of Nanocrystal Inks

4.1 Introduction

Using nanocrystals for electronic applications requires uninhibited movement of charge carriers through the nanocrystal layer. High density conduction is particularly important in operation of photovoltaic (PV) devices. As was discussed in Chapters 2 and 3, limited carrier diffusion length combined with high recombination current significantly hinder the potential for extracted current densities.

Mechanism for carrier drift and diffusion through the nanocrystal layers underline the challenges of charge collection. Individual nanocrystals are typically synthesized and dispersed with a layer of surfactant surrounding the crystalline core. Once deposited, the resulting films are heterogeneous in composition with large concentration of interfaces. Even though, movement of carriers within the crystalline grain is dominated by highly effective solid state physics, the hopping between distinct nanocrystal grains limits the carrier mobility in as-deposited nanocrystal films. Presence of the electronically insulating organic surfactant on the surface prevents crystalline cores from contacting and requires carrier tunneling for charge to move between individual nanocrystals. The conduction of carriers in nanocrystalline films have been well documented in the Pb and Cd chalcogenide based quantum dots.¹⁻¹⁰

As-deposited nanocrystal films exhibit strong Coulomb blockade at room temperature which results in reduced carrier mobilities.¹ Coulomb blockade can be mitigated with increased conduction through the film. Chemical or thermal treatment of

the as-deposited nanocrystal layer can remove a large fraction of the original ligand. Use of shorter, bi-functionalized, capping ligands (such as ethanedithiol,¹¹⁻¹² hydrazine¹³⁻¹⁴ or benzenedithiol¹⁵⁻¹⁷) can replace the synthesis ligand (which is typically much longer) on the surface, reduce interparticle spacing of crystalline grains and increase the charge mobility in the nanocrystalline film. Higher conduction eliminates buildup charge due to Coulomb blockade in the treated films.⁵ Stronger electronic coupling between nanocrystal grains can produce bulk semiconductors like conduction regimes.

As synthesized CIGS nanocrystalline grains have an average diameter of 15 nm. The crystal domains are too large to experience Coulomb blockade like the smaller Cd and Pb based quantum dots. The insulating nature of the capping ligand (oleylamine) used, however, can lead to build up and trapping of charge within the nanocrystalline films. Even so, 3% PCE devices could be fabricated from as-deposited nanocrystals.¹⁸ The ability of chemical or thermal treatment to improve conduction through the film was investigated to improve device performance. Increased conduction, however, did not translate into increased device efficiency. Chemical and thermal treatments were found to be detrimental to photovoltaic efficiencies of nanocrystal devices. The loss of efficiency is attributed to the increased defect states on the surface of nanocrystal grains with the treatment of the nanocrystal films. Higher recombination limits the benefits of higher mobility.

To prevent formation of defects in the nanocrystalline films, thermal treatments of the completed devices were performed. Once the devices are complete, the nanocrystal layer has limited access to the ambient atmosphere, reducing the kinetics of defect formation. It was discovered that a $3\times$ improvement in the J_{sc} and a $2\times$ improvement in

the overall efficiency of the devices can be achieved through post completion treatment of the devices. Impedance spectroscopies of the treated diodes indicate a reduction in the series resistance of the device with thermal treatment. Lower resistive barrier to charge extraction results in higher efficiency devices.

Impact of size, shape and composition of the nanocrystalline grains on the device performance were also investigated. Depositing larger nanocrystals with shorter ligands would significantly increase carrier mobility in the nanocrystal films. Work of Matthew Panthani has demonstrate, synthetic control over the nanocrystal product is difficult. Here we demonstrate three differently shaped nanocrystals with different overall compositions. To study improvements in device efficiency through composition and shape control requires independent synthetic control over each variable. This understanding is still lacking for the CIGS based nanocrystals. It was, however, discovered significant differences exist between different synthetic routes and precursors. “Hot-injection” synthetic route produced consistently higher efficiency devices. While the improvements in efficiency are relatively small, this research highlights the need to better understand the shape and composition of nanocrystal grains for device fabrication.

4.2 Experimental Details

4.2.1 Materials

Oleylamine (OLA) was purchased from Fisher Chemical Co. (Acros brand), and TCI America; copper (I) chloride (CuCl ; 99.99+%), selenium powder (Se ; 99.99%), tributylphosphine (TBP, 95%), and cadmium sulfate (CdSO_4 ; 99.999%) from Aldrich

Chemical Co.; indium (III) chloride (InCl_3 ; 99.999%) from Strem Chemicals; ammonium hydroxide (18M NH_3 ; ACS certified), toluene (99.99%), nitric acid (trace metal grade), and ethanol (absolute) from Fischer Scientific; and thiourea (> 99%) from Sigma-Aldrich. Oleylamine was degassed overnight by pulling vacuum on OLA heated to 110°C . All other chemicals were used as received without further purification. Copper (I) chloride, indium (III) chloride, and degassed oleylamine were stored in a nitrogen-filled glovebox to prevent degradation.

4.2.2 CuInSe₂ nanocrystal syntheses

Two different synthetic routes were examined to create nanocrystal inks. First route involved one pot synthesis of nanocrystals using elemental selenium and the second route involved direct injection of tributylphosphine (TBP) and Se complex at elevated temperatures.

A typical one-pot reaction was carried out by combining, in a three neck flask, 5 mmol of CuCl , 5 mmol of InCl_3 , 10 mmol of Se, and 50 ml of degassed oleylamine inside a nitrogen-filled glovebox. The flask necks were sealed with septa before removing the flask from the glovebox and attaching it to a Schlenk line equipped with a stirring plate and a heating mantle. The reaction mixture was stirred continuously and heated to 110°C to degas for 30 minutes by pulling vacuum. It is then purged and held under a nitrogen environment. The vessel was heated to 200°C for 30 minutes to dissolve all the constituent solids. The reaction mixture was then heated to 260°C and the reaction proceeds for an additional 10 minutes. The heating mantle is then removed and the reaction is slowly cooled to room temperature. After cooling, the flask is removed from

the Schlenk line and the reaction product is poured into glass centrifuge tubes for cleaning.

A typical hot-injection reaction was carried out in a similar three neck flask. In this case, 5 mmol of CuCl, 5 mmol of InCl₃, and 50 ml of degassed oleylamine (no selenium) were loaded into the flask inside a nitrogen-filled glovebox. All the necks were sealed with septa before removing from the flask from the glovebox and loading onto the Schlenk line. The reaction vessel was similarly degassed at 110°C for 30 minutes and refilled with dry nitrogen. While maintaining the nitrogen environment, the vessel was heated to 180°C for 5 minutes to dissolve all the solid precursors. A 10 ml solution of 1M Se in TBP (0.79g Se powder in 10 ml of TBP) was then injected through one of the septa capped necks into the reaction vessel, the reaction temperature as raised to 240°C as quickly as possible and held there for 10 minutes to complete the reaction. The heating mantle was then removed and the reaction is slowly cooled to room temperature. The content of the reaction vessel was then emptied into glass centrifuge tubes.

Both synthesis products were cleaned in identical manner. The nanocrystals were precipitated with excess ethanol and centrifugation at 4000 rpm for 2 min. After centrifugation, the supernatant was discarded and the precipitate was redispersed using a minimal amount of toluene, usually 5 ml as it depends on the yield of the reaction. The solution was then centrifuged at 4000 rpm for 1 min to remove large and poorly-capped nanocrystals. The supernatant was then transferred to a clean glass centrifuge tube and the precipitate was discarded. Ethanol was then added dropwise to the nanocrystals solution until the mixture becomes slightly turbid. The mixture was centrifuged at 4000

rpm for 1 min, after which the supernatant was discarded. The precipitate dissolved in a small amount of toluene to form 20 mg/ml suspension and was sprayed after synthesis to form active devices.

4.2.3 PV device fabrication

Sodalime glass substrates (Delta Technology) were cleaned by sonication in an acetone/isopropanol mixture, followed by rinse with DI water, and drying under nitrogen. Back contact layers containing 60 nm Au (99.95% Lesker) and 5 nm Cr (99.999% Lesker) strike layer were thermally evaporated using a Denton evaporation system. The final sheet resistance of the combined back contact structure was $\sim 3 \Omega/\square$.

Nanocrystal dispersions were deposited on the back contacts by spray deposition of 20 mg/ml dispersion of nanocrystals in toluene using a commercial spray gun (Iwata Eclipse HP-CS) operated at 50 psig head pressure. Films were sprayed in one step to a targeted thickness close to 200 nm. A thin CdS layer was deposited on the nanocrystal layers immediately after spray deposition. To fabricated photovoltaic devices, the CdS deposition was followed by 50 nm of AC sputtered ZnO (99.9% Lesker, 5 ppm O₂ in Ar sputtering gas) and 600 nm layer of sputtered ITO (99.99% Lesker, UHP Ar sputtering gas) to complete a transparent top electrode. With the final active area of the device is 8 mm², a 4 mm by 2 mm rectangle. To make the devices used for Mott-Schottky analysis, 50 nm of AC sputtered ZnO was followed by 50 nm of thermally evaporated Al (99.99% Lesker). The area of the devices were similar at 8 mm².

4.2.4 Characterization

Current-potential (IV) characteristics were collected using a Keithley 2400 general purpose source meter and a Xenon lamp solar simulator (Newport) equipped with an AM1.5 optical filter. Intensity of the light source was calibrated using a NIST calibrated Si photodiode (Hamamatsu, S1787-08).

Impedance characteristics of the photovoltaic cell were collected using a Solartron 1260A Frequency Response Analyzer coupled with a Solartron 1296 Dielectric Interface. Measurements were taken between 0.1 Hz and 10^7 Hz with 5 steps per decade by applying a 50 mV A-C waveform.

ICP-ms measurements were performed on digested solution of CuInSe_2 nanonanocrystals in aqueous solutions. A 3 mg sample of the dry nanocrystals was digested in 200 μL of highly concentrated nitric acid. The digestion was allowed to proceed for 60 minutes. After which, the resulting lime green solution was diluted 35,000x with 2% nitric solution in DI water. Blank controls were prepared at all stages of the digestion, and no significant concentration of desired elements was found in any of the blanks. Analysis of purchased standards shows the measurements is accurate to parts per trillion (PPT) levels, 5 orders of magnitude smaller than our measured concentrations.

XRD data was collected on a Bruker-Nonius D8 advance θ - 2θ powder diffractometer equipped with a Bruker Sol-X Si(Li) solid state detector and a rotating stage. 1.54 Å radiation (Cu K_α) was used to collect at 0.01 increments of 2θ at a scan rate of 6 °/min. XRD was collected on the absorber films that were subsequently completed into devices.

4.3 Changes to Nanocrystal Synthesis

Nanocrystal shape and composition impact the efficiency of PV devices. Variations to the synthetic route previously developed¹⁹ involve different selenium sources or using different supplier of oleylamine precursor. The changes to shape and composition of the nanocrystals is shown in Figure 4.1. The original one-pot synthesis was discovered by Panthani, et. al.¹⁹ and is dubbed an “elemental-Se” reaction. In the one-pot reaction, Cu and In chlorides, elemental Se and Acros oleylamine (purchased through Fisher) were loaded into a 3-neck flask and heated to 240°C to complete the reaction.¹⁹ Figure 4.1A shows the TEM of CuInSe₂ nanocrystals produced through this synthesis. The resulting crystals are polydisperse in size with an average diameter of 15 nm. The product shape is either semi-spherical or disk like. ICP-ms measurements of the nanocrystal inks, inset to Figure 4.1A, shows the product composition is very close to the stoichiometric Cu:In:Se ratios at 1.00:1.02:2.15. Figure 4.1B shows a typical IV response for a device built from this set of particles. The efficiency of CuInSe₂ devices build from the nanocrystal set are below 1% PCE.

A modification to the reaction involved using “hot-injection” method to deliver the selenium source. In this method, Cu and In chloride salts were dissolved in Acros oleylamine. In a parallel flask, the TBP and selenium mixture was prepared. The salts mixture was heated to 180°C, the TBP:Se solution was injected into the reaction vessel²⁰ and the reaction was allowed to proceed for 15 minutes at 240°C. This reaction chemistry is referred to as a TBP:Se synthesis. Figure 4.1C shows typical TEM image of the resulting product. The crystals are still polydisperse and retain an average diameter around 15 nm, but they are no longer semi-spherical. The crystalline product is much more faceted than the elemental-Se reaction described previously. ICP-ms measurements

of the nanocrystal composition shows that the product is copper poor, the Cu:In:Se ratios in the product are 1.00:1.20:2.25. This reaction gave a lower yield compared to the elemental Se reaction, but the device efficiencies were better. Figure 4.1D shows a typical IV response from devices built from this reaction set. Typical device efficiencies were above 1% PCE, and the most efficient devices were fabricated from nanocrystal inks synthesized through this method.¹⁸

Another modification to the reaction chemistry involved the use of different oleylamine precursors for the reaction. Several different sources of oleylamine were studied. Oleylamine was purchased from Acros, Aldrich, Corsitech, Evonik, and TCI chemical companies. All the sources were less than 95% pure oleylamine, but the impurities present have been difficult to identify. Different sources (and even different batches) of oleylamine have resulted in differences in reaction chemistry. Figure 4.1 E-F shows the results associated with running an elemental-Se reaction using TCI oleylamine. Typical TEM scan of this reaction, Figure 4.1E, reveals that the crystalline product is larger than the reaction using Acros oleylamine. The product has irregular shaped plate-like features associated with it. Average diameter of this product is difficult to measure as the individual nanocrystals are overlapping in the TEM images. Nanocrystals as large as 60 nm in diameter and as small as 10 nm in diameter are present. ICP-ms analysis of the nanocrystal composition shows that this product set has very high copper deficiency. The measured composition is Cu:In:Se ratios of 1.00:1.55:2.70. Typical IV response of devices prepared by this set of nanocrystal inks is shown in Figure 4.1F. Typical efficiencies of such devices are above 1% PCE as well. For the elemental-Se reaction,

TCI oleylamine nanocrystals produce higher efficiency devices than the Acros oleylamine nanocrystals.

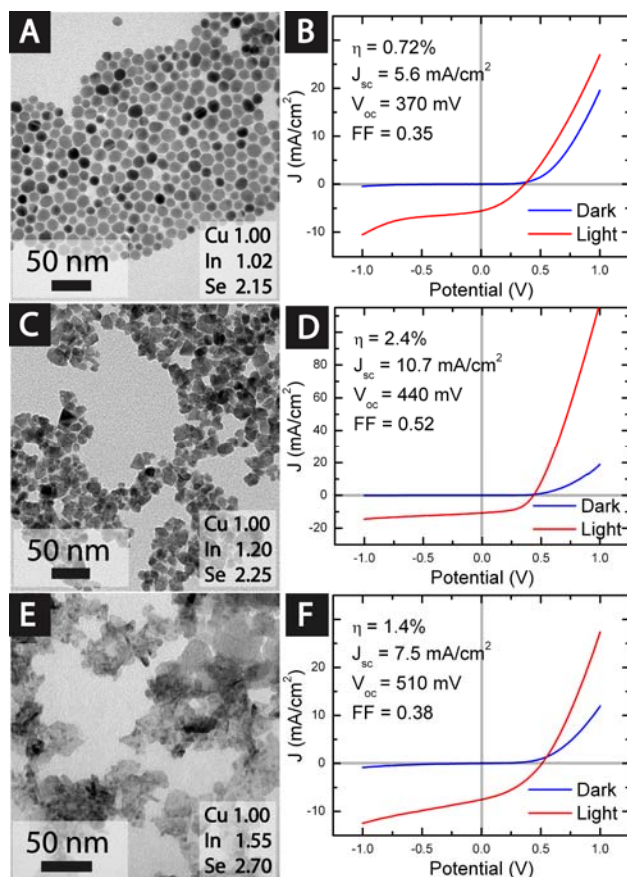


Figure 4.1. TEM of CuInSe₂ nanocrystals, composition of nanocrystal inks as measured by ICP-ms analysis and IV response of devices prepared by using the nanocrystal inks. (A-B) Correspond with results gathered from an elemental-Se reaction using Acros oleylamine, (C-D) correspond with results gathered from a TBP:Se reaction using Acros oleylamine, and (E-F) correspond with an elemental-Se reaction using TCI oleylamine. TEM images courtesy of Matthew Panthani and C. Jackson Stolle.

For the nanocrystal inks investigated, both shape and composition changed with changes to reaction chemistry or precursors. It is important to further study the reason behind the changes in both composition and shape. Control over shape of CIGS nanocrystals has been demonstrated,²¹ but control of composition is still lacking.

Separating the impact of composition from the shape would clarify the role of intrinsic dopants on carrier recombination and impact of the larger grains on the higher carrier mobility in the nanocrystal films.

The TBP:Se hot injection CuInSe₂ reaction resulted in higher efficiency devices. FTIR and XPS measurements of the surface show that the presence of TBP did not alter the surface coverage of ligands on the surface. To study the role of the selenium precursor on the reaction chemistry, the injection temperature for the precursor was altered to understand the role of the injection temperature on nanocrystal synthesis. Figure 4.2 shows the device parameters and the composition of the synthesized product as a function of the injection temperature. After injection, the reaction temperature was raised to 240°C and allowed to react for 15 minutes.

The injection temperature does impact the fabricated devices, and higher temperature injection results in better efficiency devices. Injection above 180°C, however, resulted in unstable nanocrystalline product and the deposition of the inks limited the efficiency of the devices. The improvements in efficiency of the devices are due to improvements in the short circuit current density (J_{sc}) of the devices at higher injection temperatures, Figure 4.2B. The improvement in J_{sc} can be attributed with a reduction in doping density (N_A) of the nanocrystalline absorber layer as measured by Mott-Schottky analysis of the junction, and a deeper space charge region. As discussed in Chapter 3, deeper space charge region would result in improved collection of the photogenerated carriers. The reason behind this trend might be the rapid synthesis of nanocrystals upon availability of the selenium precursor.

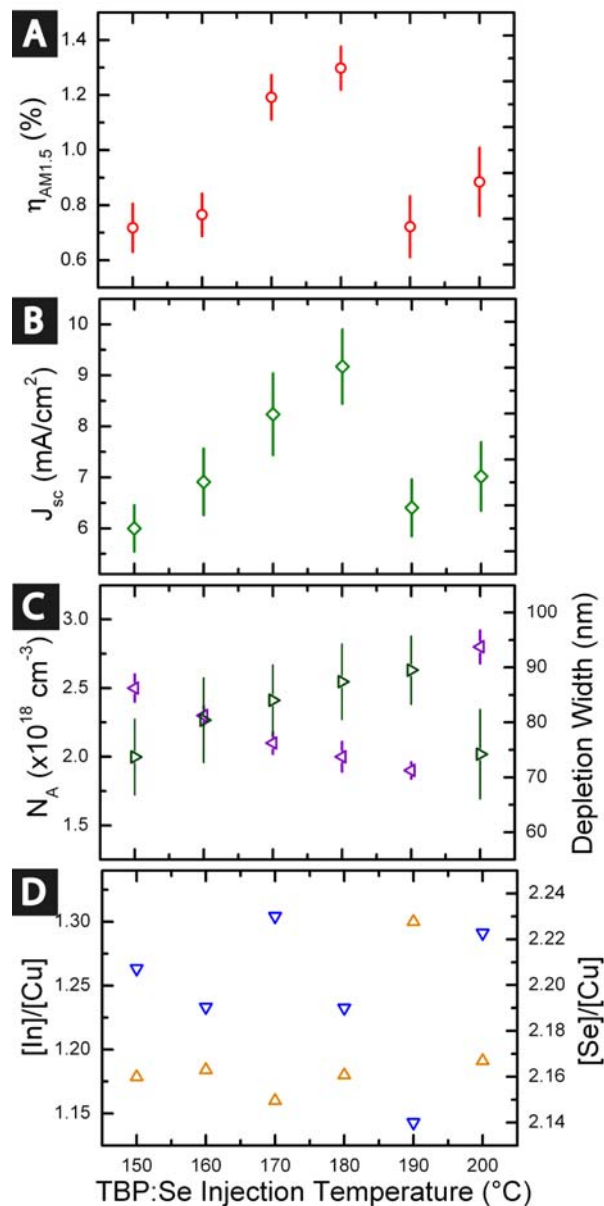


Figure 4.2. (A) Efficiency and (B) short circuit current density of devices prepared from CuInSe₂ nanocrystal inks synthesized by hot injection of TBP:Se at different injection temperatures. (C) Measured doping density (N_A) based on Mott-Schottky analysis of the junction marked by (\blacktriangleleft) and the calculated depletion width marked by (\blacktriangleright), marked on the right axis. (D) Composition of the resulting nanocrystal inks as measured by ICP-ms analysis, In:Cu ratio is marked by (\blacktriangle) and the Se:Cu ratio is marked by (\blacktriangledown).

There is some deviation in the composition of the nanocrystalline inks with changes to the injection temperature, Figure 4.2D. The deviations in the composition are not correlated with changes to the injection temperature. Furthermore, the variations in composition do not signal changes in device characteristics. Further work is necessary to outline the reasons for the variations and understand the reason behind improved charge collection at higher injection temperatures.

Variations in synthetic chemistry led to improvements in the device properties, but the improvements have been too small to produce commercially viable devices. A full study of the variables that independently control nanocrystal size, shape and composition is necessary for better understanding of the limitations associated with the inks synthesis. The limiting factor for the overall device efficiency, however, lies with the limited carrier conduction through the electronically insulating capping ligand layer.

4.4 Removing Capping Ligand through Thermal and Chemical Treatment

As-deposited nanocrystal films are a composite of inorganic cores nestled in a matrix of organic ligands. Carriers can travel easily through the inorganic semiconductor cores, but are trapped by the electronically insulating nature of the organic ligands. As such, CIGS nanocrystal films have on average an order of magnitude lower conductivity than the vapor deposited semiconductors.²² While the organic ligands are necessary for solution deposition of the colloidal inks, they hinder device performance after the deposition. One way to improve extracted J_{sc} is to remove the organic ligands and increase the mobility within the film. This transformation has already been documented for Pb and Cd based chalcogenide nanocrystal films.¹⁻⁹ In the reported cases, thermal and chemical treatment of the absorber layer were used to increase the mobility of carriers

within the nanocrystal films. Reports of chemically treated Pb chalcogenide quantum dot solar cells have been published.²³ The work here investigated thermal and chemical treatments on the nanocrystalline CIGS films in an effort to improve PV device performance.

Thermal treatment of as-deposited nanocrystal films under different non-reactive gas environments were investigated between 200°C and 500°C. It was discovered that annealing under atmospheric, low vacuum or “pure” nitrogen environments resulted in rapid formation of metal oxides (CuO, In₂O₃, and Ga₂O₃) in the nanocrystal layer. The parts-per-million concentrations of oxygen present was sufficient to supply the oxide formation. To eliminate any source of oxidant, thermal treatment under forming gas environment (7% H₂ and 93% N₂) was undertaken. Hydrogen present in forming gas, makes the annealing atmosphere slightly reducing. Anneals under forming gas resulted in significant outgassing of selenium from the crystalline core, and formation of Cu/In alloys in the film. All devices build from treated layers exhibited an ohmic response. The formation of the byproducts resulted in loss of p-type semiconductive behavior of the CIGS nanocrystal films. No sintering of crystalline cores was observed under different environments and temperatures. Photo-electrochemical (PEC) tests of the treated nanocrystal layers corroborated the solid state device findings.²⁴

Removal of the ligands through chemical treatment of the as-deposited film is a lower temperature treatment and reduces the possibility of metal oxide formation. Figure 4.3 presents the device characteristics of diodes built from hydrazine treated nanocrystal absorber layers. Treatment with hydrazine is known to remove amine functionalized capping ligands from the surface of nanocrystal grains.¹⁴ With the removal of the

oleylamine and the replacement with a much shorter capping ligand (hydrazine), the interparticle spacing between crystalline grains can be significantly reduced.^{8, 14} As the concentration of hydrazine in the treatment solution is increased, more oleylamine can be lifted from the surface of the particles. As more oleylamine is taken off, however, the device efficiency of the resulting films decreases rather than increase. Changes in V_{oc} and FF of the devices are minimal, but a steady decrease in the J_{sc} of the devices leads to a decreasing trend in PCE of the solar cells. Similar to thermal treatment of the films, the decrease in the J_{sc} is contrary to what would be expected with the increased mobility of carriers in the nanocrystalline films.

Chemical or thermal removal of the electronically insulating capping ligands results in several undesired changes to the nanocrystal system. First, thermal treatments in presence of oxygen leads to oxidation of the nanocrystal surface, and removal of the ligand could expose parts of the surface to the ambient for oxidation. Secondly, outgassing of selenium or a binary product including In or Cu leads to formation of undesired pockets for compositional heterogeneity that act as recombination sites. Finally, the oleylamine capping ligand is acting as an electronic counter charge to the surface site and removal of the ligand could activate the surface as possible recombination site.

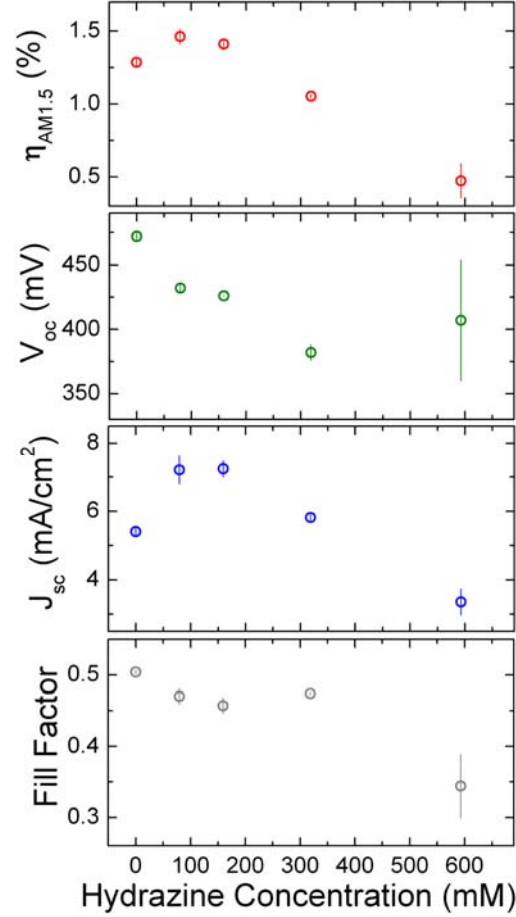


Figure 4.3. Device characteristics of nanocrystalline CuInSe₂ PVs. The nanocrystal layers were treated with different concentrations of hydrazine in acetonitrile for 60 minutes after spray casting and before CdS deposition.

A viable treatment option, to increase mobility within the nanocrystal films but limit formation of undesired recombination sites involves thermal treatment of completed devices. Thermal treatment of completed devices is different than thermal treatment of the nanocrystal films. Completed devices are capped, limiting the possible oxidation of the absorber layer and limiting the outgassing of volatile selenium or binary products. At the same time, presence of Cd ions, introduced during the CdS deposition, can passivate the surface of the nanocrystal grains, where the capping ligands have been removed. Thermal treatment of the completed devices improves the overall device efficiency.

Figure 4.4A shows the response of a set of CuInSe₂ nanocrystal devices with thermal treatment of the completed devices in a vacuum oven at 200°C for different lengths of time. A 3× improvement in the J_{sc} of the devices is observed with the thermal treatment of the completed devices. The V_{oc} and FF of the devices deteriorate with longer bake times, but the improvement in the overall extracted photocurrent is sufficient to result in doubling of the device efficiency through post completion baking.

The source of improvement in the device efficiency is difficult to pinpoint as several different changes take place with the thermal treatment of the completed devices. Impedance spectroscopy of the as prepared devices, Figure 4.4B, shows that several different capacitive effects are present in the as-prepared diode. Several different peaks are present in the phase angle spectrum of as-prepared device, and these peaks correspond to build-up of charge at different interfaces in the device. With the thermal treatment, some of these junctions are passivated, and less charge is buildup in the devices. With longer thermal treatment, the overall resistance of the device is reduced. Figure 4.4C shows the change in the calculated series resistance for the devices, there is a trend of lower series resistance with longer bake times. There is a difference between the series resistance in the dark and under illumination, and as was discussed in Chapter 3, the deviation is a result of photoactivity of the CdS layer.

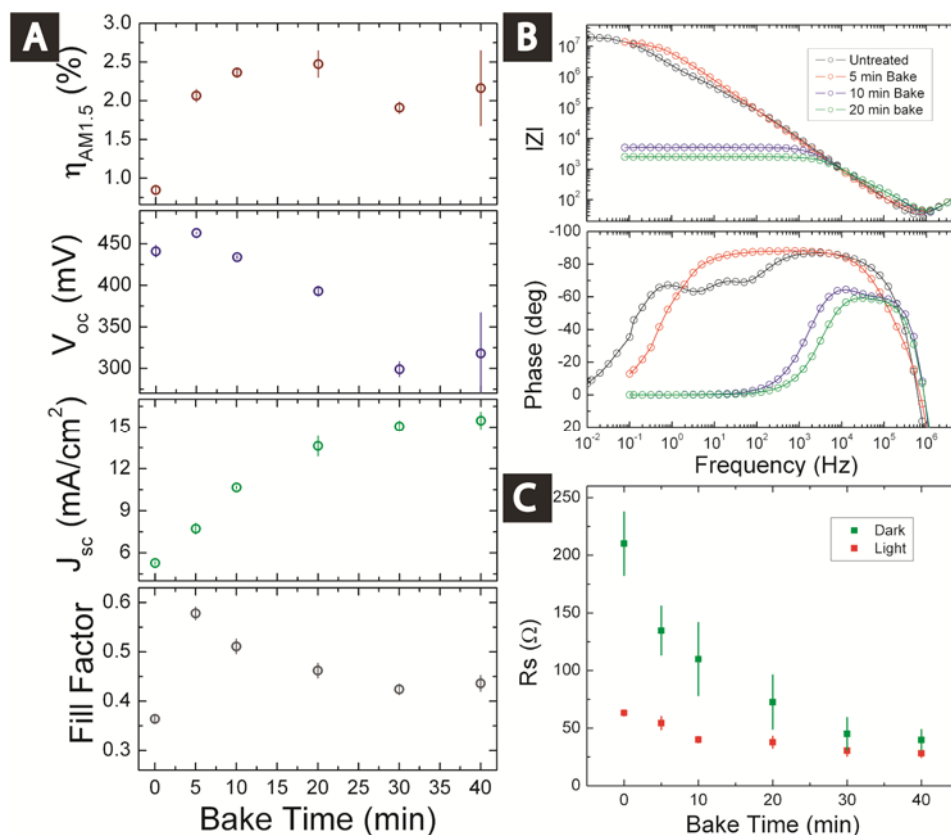


Figure 4.4. (A) Device characteristics of CuInSe₂ nanocrystal devices baked in a vacuum oven at 200°C for variety of lengths of time. (B) Impedance response of the resulting diodes baked for different lengths of time. (C) Change in series resistance of the diode in dark conditions and under illumination with AM 1.5 radiation after baking for different lengths of time.

4.5 Summary

Variations in nanocrystal shape and composition resulted in variation in observed device characteristics and efficiency. In this work, it was observed that larger nanocrystals with copper deficiency exhibited the highest device efficiencies. Independent control over the shape and composition are necessary to understand the relative impact of each variable on device performance and is the course of further research. Impurities in the oleylamine solvent and capping ligand impact the synthetic chemistry, determining the impurities present and classifying their impact is important to

understand the mechanism of the CIGS nanocrystal growth. It was further determined that a hot injection synthesis of CuInSe₂ nanocrystals produced particles that exhibited better efficiencies in devices than a one pot synthesis using elemental selenium.

Thermal and chemical treatments of the as-deposited nanocrystal films deteriorate the efficiency of the fabricated devices. The improvement in carrier mobility by removing the electronically insulating ligand is offset by possible oxidation and electronic trap formation due to ligand removal. Increased trap density results in higher recombination current and shallower space charge region for photogenerated carrier collection. Comprehensive treatments are needed to remove the insulating capping ligands but neutralizing possible trap sites. Thermal treatment of the completed nanocrystalline devices significantly improves the overall efficiency. Reduction of the series resistance to charge extraction is a possible reason for the improved efficiency.

For removal of electronically insulating ligands to be successful, it needs to be accompanied by significant grain growth to reduce the number of surface defect sites. Discussion in the next chapter focuses on thermal treatment in a reactive atmosphere to remove the insulating ligand, and promote growth of crystalline grains.

4.6 Notes and References

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Chapter 5: Selenization and Grain Growth of CIGS Nanocrystal Films

5.1 Introduction

At 3% PCE,¹ the CIGS nanocrystal-based absorber photovoltaics are not efficient enough for commercial viability. Ideas for improving device efficiency without resorting to high temperature processing include better light management², low temperature treatment of as-deposited films (Chapter 4) or using 1-D nanostructures for better charge collection.³ However, none of these routes have achieved significant improvements in device efficiency. As outlined in chapter 3, charge collection in the devices could be improved by reducing the doping density and increasing the depletion width. Hillhouse and Agrawal have demonstrated that high temperature selenization sinters the nanocrystal films to obtain crystalline grain sizes of micrometer and enabled device efficiencies as high as 5.5%.⁴ Selenization could conceivably increase device efficiency above the 10% threshold deemed necessary for commercialization. Larger crystal grains improved carrier mobility by reducing the need to hop from one crystalline grain to another. At the same time, reducing the surface to volume ratio eliminated many of the surface sites, reducing possible surface trapping of carriers.

Simply heating the nanocrystal films to high temperature, above 400°C for example, does not result in significant grain growth. The heating requires Se vapor to induce sintering and significant grain growth. This selenization process is widely used to fabricate CIGS PV devices with efficiencies above 15%.¹¹ The selenization of metal alloy films have been extensively studied and grain growth has been observed in metal films selenized at temperatures as low as 260°C.^{5, 6} Significant grain growth has not been

observed in nanocrystal films selenized at temperatures lower than 400°C. The high temperature selenization of nanocrystal films is discussed, along with challenges associated with selenization and solutions to these challenges.

The band gap energy of CIGS can be tuned for improved device performance by manipulating the In:Ga ratio.⁸ The Ga content can be manipulated by changing the In:Ga precursor ratios in the nanocrystal synthesis.⁹ It is demonstrated in this report that the inks composition translates into the working bandgap of the selenized nanocrystal device. Selenized nanocrystal CIGS films share electronic bandgap with similar composition vapor deposited films. Furthermore, it was determined that both the Ga:In and the Cu:In ratios influence the device performance. While the Ga to In ratio determine the bandgap of the absorber layer, the Cu to In ratio determines the extent and morphology of grain growth.

5.1% PCE devices were fabricated through selenization of CIGS nanocrystal films. Light beam induced current microscopy (LBIC) measurements were used to characterize the variations in device response and improve the selenized absorbers. Using the LBIC technique, several different features were characterized. For example, residual capping ligand remained after the selenization process and better removal of the organic capping ligand is necessary for higher efficiency devices. The selenization process eliminates many advantages associated with ambient processing of nanocrystal films. Unlike the nanocrystal devices discussed previously, the selenized nanocrystal devices could only be built in the conventional device geometry. None the less, fabrication of devices flexible substrates was possible and prototype devices are demonstrated.

5.2 Experimental

5.2.1 Materials

Oleylamine (OLA) was purchased from TCI America or Corsitech; copper (I) chloride (CuCl ; 99.99+%), gallium (III) chloride (GaCl_3 ; 99.999+%), selenium powder (Se ; 99.99%), and cadmium sulfate (CdSO_4 ; 99.999%) from Aldrich Chemical Co.; indium (III) chloride (InCl_3 ; 99.999%) from Strem Chemicals; ammonium hydroxide (18M NH_3 ; ACS certified), toluene (99.99%), ethanol (absolute), and nitric acid (trace metal grade) from Fischer Scientific; and thiourea (> 99.0%) from Sigma-Aldrich. Oleylamine was degassed overnight by pulling vacuum on OLA heated to 110°C. All other chemicals were used as received without further purification. Copper (I) chloride, indium (III) chloride, gallium (III) chloride, and degassed oleylamine were stored in a nitrogen-filled glovebox to prevent degradation.

5.2.2 $\text{CuIn}_{1-x}\text{Ga}_x\text{Se}_2$ (CIGS) nanocrystal synthesis

A typical reaction was carried out by combining, in a three neck flask, 5 mmol of CuCl , 10 mmol of Se , 50 ml of degassed oleylamine, and 0-5 mmol of InCl_3 and GaCl_3 totaling 5 mmols inside a nitrogen-filled glovebox. The flask necks were sealed with septa before removing the flask from the glovebox and attaching it to a Schlenk line equipped with a stirring plate and a heating mantle. The reaction mixture was stirred continuously and heated to 110°C to degas for 30 minutes by pulling vacuum. It was then purged and held under a nitrogen environment. The vessel was heated to 200°C for 30 minutes to dissolve all the constituent solids. The reaction mixture was then heated to 260°C and the reaction proceeds for an additional 10 minutes. The heating mantle is then

removed and the reaction is slowly cooled to room temperature. After cooling, the flask is removed from the Schlenk line and the reaction product is poured into glass centrifuge tubes. The nanocrystals were precipitated with excess ethanol and centrifugation at 4000 rpm for 2 min. After centrifugation, the supernatant was discarded and the precipitate was redispersed using a minimal amount of toluene, usually 5 ml and depends on the yield of the reaction. The solution was then centrifuged at 4000 rpm for 1 min to remove large and poorly-capped nanocrystals. The supernatant was then transferred to a clean glass centrifuge tube and the precipitate was discarded. Ethanol was then added dropwise to the nanocrystals solution until the mixture became slightly turbid. The mixture was centrifuged at 4000 rpm for 1 min, after which the supernatant was discarded. The precipitate dissolved in a small amount of toluene to form 200 mg/ml suspension and was stored in the glovebox for future use.

5.2.3 *CuInS₂ nanocrystal synthesis*

A typical reaction is carried out by combining 2 mmol of indium (III) acetylacetonate (InACAC), 2 mmol of copper (I) acetylacetonate (CuACAC), and 14 ml of dichlorobenzene (DCB) in a three neck flask (reaction flask). In a separate three neck flask, 4 mmol of elemental sulfur is dissolved in 6 ml of DCB. Both flasks are attached to a Schlenk line and degassed at room temperature for 30 minutes, purged with nitrogen, and degassed for an additional 30 minutes. Both flasks are then purged and held under nitrogen and 4 ml of degassed oleylamine is added to the Cu and In containing flask (i.e. the reaction flask). The reaction flask is then heated to 182°C on a heating mantle while being gently agitated by a stir bar. Once the reaction flask reaches 110°C, the

sulfur:DCB mixture is drawn up into a glass syringe and injected into the reaction flask. The reaction then proceeds for 1 hr once the reaction mixture reaches 182°C. The heating mantle is then removed and reaction is slowly cooled to room temperature. After cooling, the flask is removed from the Schlenk line and the reaction product is poured into glass centrifuge tubes. The nanocrystals are precipitated by with excess ethanol and centrifugation at 4000 rpm for 2 min. After centrifugation, the supernatant is discarded and the nanocrystals are redispersed using a minimal amount of toluene. The solution is then centrifuged at 4000 rpm for 2 min to remove large and poorly-capped nanocrystals. The supernatant is then transferred to a clean glass centrifuge tube and the precipitate is discarded. Ethanol is then added drop wise to the nanocrystals solution until the mixture becomes turbid. The mixture is centrifuged at 4000 rpm for 2 min after which the supernatant is discarded and the precipitate dissolved in a small amount of toluene in order to create a concentrated nanocrystals solution. The solution is stored in the concentrated form in a glovebox until used.

5.2.4 PV device fabrication

Sodalime glass substrates (Delta Technology) were cleaned by sonication in an acetone/isopropanol mixture, followed by rinse with DI water, and drying under nitrogen. Back contact layers of 1 μm Mo (99.95% Lesker, UHP Ar sputtering gas) was deposited by sputter coating in a two-step process. 400 nm of Mo was deposited at 5 mtorr to create a highly adhesive layer to the sodalime glass, and an additional 600 nm of Mo was deposited at 1.5 mtorr for a highly conductive layer. The final sheet resistance was $\sim 1.25 \Omega/\square$.

Nanocrystal dispersions were deposited on the Mo back contacts by spray deposition of 20 mg/ml dispersion of nanocrystals in toluene using a commercial spray gun (Iwata Eclipse HP-CS) operated at 50 psig head pressure. Films were sprayed in one step to a targeted thickness of 1.5 μm . The films were annealed in a hollow graphite cylinder with excess elemental selenium. The cylinder was firmly capped but not gastight. A two-step annealing process was used; 10 minutes at 350°C to remove the organic ligands and then raising the temperature to 500°C for 1 hour, for more details see the selenization section of results. Excess Se provides a partial pressure to ensure limited loss of selenium content from the particles.

Following the nanocrystals selenization, a thin CdS layer was deposited by chemical bath deposition (CBD). In summary, 160 ml of 18.2 M Ω DI water was placed in a crystallization dish with a stir bar, and the contents were raised to 70°C. 25 ml of 15 mM CdSO₄, 12.5 ml of 1.5 M thiourea and 32 ml of ammonium hydroxide are added to the preheated DI water and the selenized film are immediately placed inside the bath. The reaction is allowed to proceed for 20 minutes. The films are then washed with DI water and dried. The CdS CBD is followed by 50 nm of AC sputtered ZnO (99.9% Lesker, 5 ppm O₂ in Ar sputtering gas) and 600 nm layer of sputtered ITO (99.99% Lesker, UHP Ar sputtering gas). The final active area of the device is 25 mm², a 10 mm by 2.5 mm rectangle. After the top contact deposition, however, a grid of silver paint was painted on the device, reducing the actual illuminated device area to 14 mm². Completed devices were placed in a vacuum oven at 200 °C for up to 60 hrs to improve the performance.

5.2.5 Characterization

Current-potential (I.V) characteristics were collected using a Keithley 2400 general purpose source meter and a Xenon lamp solar simulator (Newport) equipped with an AM1.5 optical filter. Intensity of the light source was calibrated using a NIST calibrated Si photodiode (Hamamatsu, S1787-08). Incident photon-to-electron conversion efficiency (IPCE) measurements were collected as a measure of external quantum efficiency using an in-house fabricated spectrophotometer. Monochromatic light was generated using a commercial monochromator (Newport Cornerstone 260 1/4M). Generated light was chopped at 213 Hz and was focused to a spot size of 1 mm in diameter on the active region. The response of the device was recorded at zero bias between 300 and 1300 nm in 10 nm steps using a lock-in-amplifier (Stanford Research Systems, model SR830). The light intensity was calibrated using calibrated photodiodes of silicon (Hamamatsu) and germanium (Judson).

Impedance characteristics of the photovoltaic cell were collected using a Solartron 1260A Frequency Response Analyzer coupled with a Solartron 1296 Dielectric Interface. Measurements were taken between 0.1 Hz and 10^7 Hz with 5 steps per decade by applying a 50 mV A-C waveform.

ICP-ms measurements were performed on digested solution of CIGS nanoparticles in aqueous solutions. A 3 mg sample of the dry nanocrystals was digested in 200 μ L of highly concentrated nitric acid, and the digestion was allowed to proceed for 60 minutes. After which the resulting lime green solution was diluted 35,000x with 2% nitric solution in DI water. Blank controls were prepared at all stages of the digestion, and no significant concentration of desired elements was found in any of the blanks.

Analysis of purchased standards shows the measurements is accurate to parts per trillion (PPT) levels, 5 orders of magnitude smaller than our measured concentrations.

XRD data was collected on a Bruker-Nonius D8 advance θ – 2θ powder diffractometer equipped with a Bruker Sol-X Si(Li) solid state detector and a rotating stage. 1.54 Å radiation (Cu K α) was used to collect at 0.01 increments of 2θ at a scan rate of 6 °/min. XRD was collected on the absorber films that were subsequently completed into devices.

X-ray photoelectron spectroscopy (XPS) spectra were collected using a Kratos Photoelectron Spectrophotometer equipped with a tungsten coil charge neutralizer, high intensity monochromatic Al-K α X-ray source, and a 180 hemispherical electron energy analyzer. The charge neutralizer was operated at constant 4.8 V during data collection. Collected spectra were analyzed using CasaXPS software. Details of charge collection and peak fitting are provided in the results section.

5.3 Selenization of CIGS Nanocrystals

Selenization of nanocrystal films took place inside a graphite box, Figure 5.1A-B. The graphite box acts as a vessel to retain a positive pressure of selenium. Excess selenium pellets were placed inside the box. The selenium pellets melt and evaporate during the heating process, increasing the partial pressure of selenium in the processing atmosphere. Nanocrystal films on Mo coated glass were placed inside the box with the nanocrystal film facing away from the Se source. The box was sealed with a graphite plug and placed in the central zone of a tube furnace, pictured in Figure 5.1C. The tube furnace was sealed and purged with pure argon to achieve an inert atmosphere. The inert

atmosphere of the tube prevented undesired oxidation of the selenized film, and the box limited loss of selenium from the nanocrystal films. The tube furnace was heated up to selenization temperature (typically 500°C) for 60 minutes, and then cooled down to room temperature. The graphite box was opened within an inert atmosphere glovebox and the films were removed and saved in the glovebox prior to the CdS deposition step.

Figure 5.2A shows the XRD spectrums of CuInSe₂ nanocrystals films on Mo coated glass before and after selenization. The XRD reflection peaks associated with the CuInSe₂ layer become sharper after selenization, signaling a significant growth of the grains. Cross sectional SEM images of the absorber layer before (Figure 5.2B) and after (Figure 5.2C) selenization reveal extent of crystal growth. The common crystal growth involved formation of a dense film of crystals at the absorber/back contact interface, topped with amorphous byproduct. Under the selenization conditions, a layer of MoSe₂ was observed to grow at the absorber layer and Mo interface. The MoSe₂ provides an ohmic contact between the new CIGS crystals and the remaining Mo back contact. The presence of the MoSe₂ layer is detectable through the XRD pattern of the selenized films, Figure 5.2A. Formation and the impact of the MoSe₂ layer are further discussed in section 5.3.3.

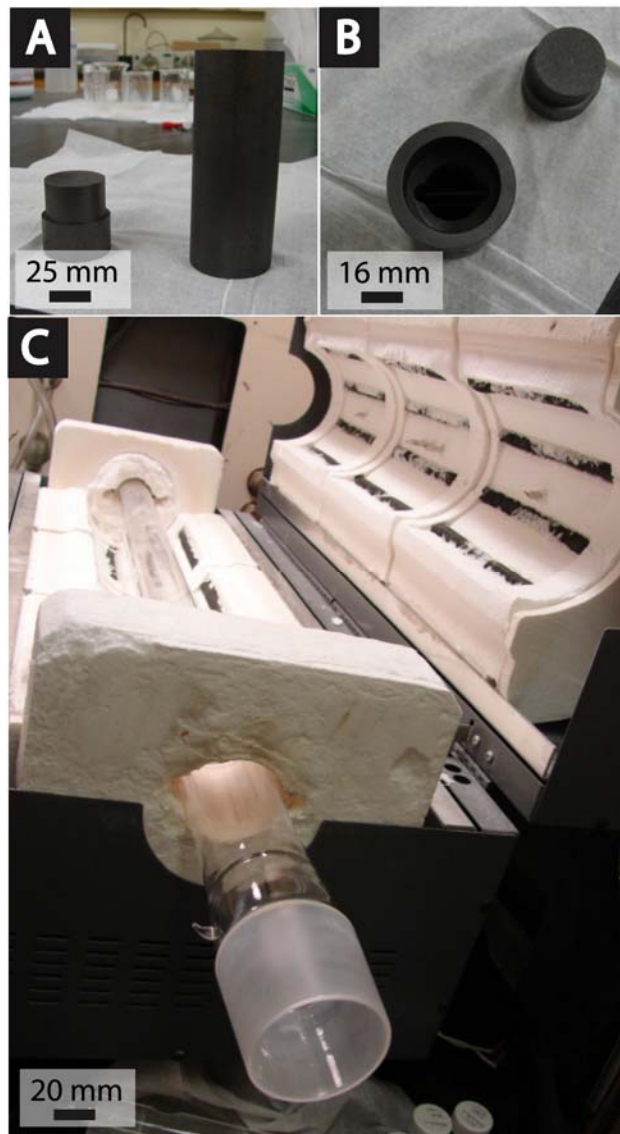


Figure 5.1. (A) Side view and (B) cross-sectional view of the selenization box used for sintering of nanocrystal layers. The cylinder is capped with the plug to ensure buildup of a selenium partial pressure. (C) Tube furnace used for heating the selenization box.

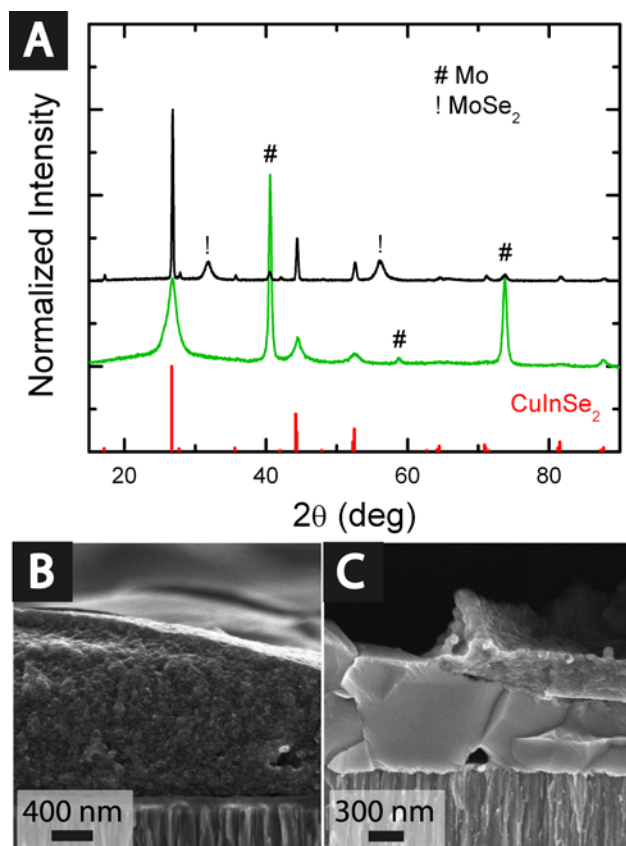


Figure 5.2. (A) XRD pattern of CIS films before and after selenization, matching well with the established crystal structure of CuInSe₂ (PDF#97-006-8928) (B) SEM image of cross section of an as-deposited CuInSe₂ film and (C) selenized CuInSe₂ film.

Grain growth was essential to extract higher short circuit current density (J_{sc}) from the absorber film. Light beam induced current microscopy (LBIC) measurements had been previously used to characterize nanocrystal layers.¹⁸ LBIC technique was used in this work to correlate morphology of the selenized film with increased photocurrent from the selenized devices. Figure 5.3A shows the spatial SEM micrograph of a selenized CuInSe₂ film. Figure 5.3B shows the cross-sectional SEM image of the same absorber. There is significant grain growth by selenization. For this film, however, grain growth

was confined to the back contact interface. At the same time, most of the new crystals are capped with islands of amorphous byproduct. LBIC map of the final device, Figure 5.3C, reveals extensive heterogeneity in the photocurrent of the active region.

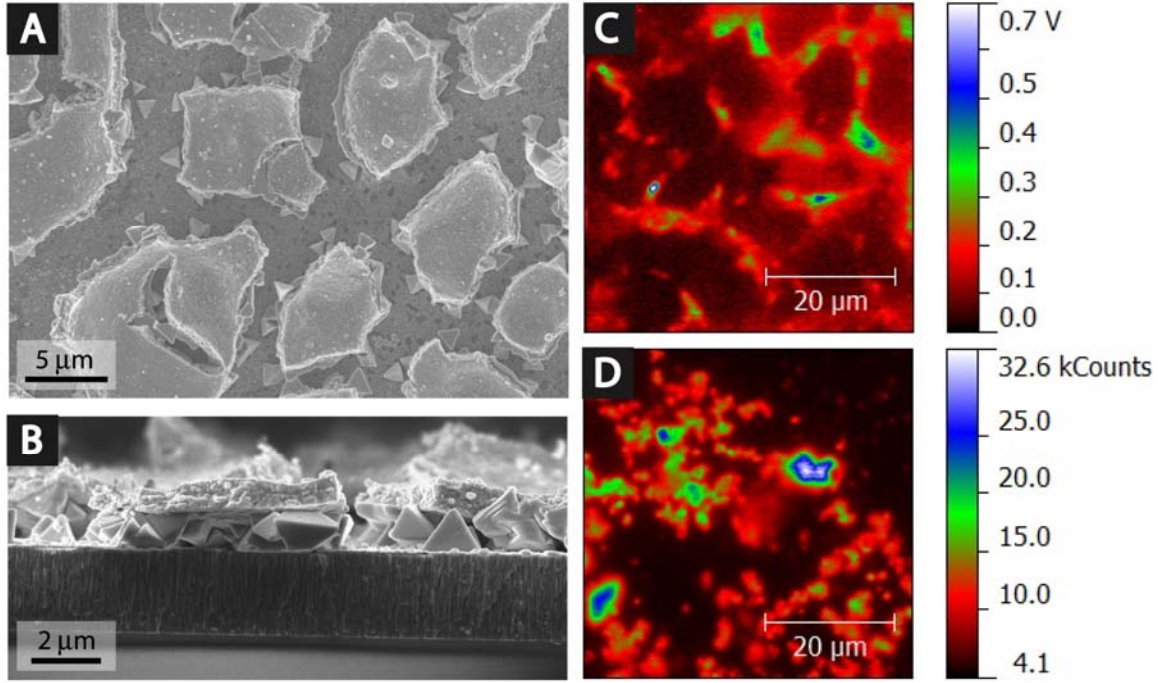


Figure 5.3. (A) Spatial and (B) cross section SEM image of selenized CuInSe_2 film. (C) Shows the response of light beam induced current microscopy (LBIC) measurements and (D) fluorescence microscopy image of device prepared with the selenized film. LBIC data courtesy of Micah Glaz.

LBIC maps of the active device layer reveal regions that are highly active and regions which yield much smaller photocurrent. Comparing the SEM image of the absorber layer (Figure 5.3A) to the LBIC map (Figure 5.3C), regions of high photocurrent (represented by the higher potential bias) correspond closely with larger grains. Regions with small photocurrent are either areas with exposed back contact or are the amorphous byproduct. Cross-sectional SEM images (Figure 5.3B) show that there

are larger CIGS crystals under the amorphous byproduct, but these crystals are not active in photocurrent generation.

Never the less, devices prepared with selenized absorber layers yield a much higher J_{sc} under illumination. Figure 5.4A shows the current-potential (IV) response of two devices prepared from the same set of CIGS nanocrystal inks. First device was built using as-deposited nanocrystal film, as was discussed in chapter 2, with the Au/CIGS/CdS/ZnO/ITO structure. The second device was spray deposited under ambient conditions on Mo back contact and the absorber layer was selenized at 500°C before incorporation into a working photovoltaic. The increased J_{sc} from 4.5 mA/cm² to 13.5 mA/cm² is indicative of better carrier collection in the selenized films.

Mott-Schottky measurements of the films, Figure 5.4B, reveal a modest reduction of the doping density (N_A) in the selenized absorber, from $2 \times 10^{17}/\text{cm}^3$ to $1 \times 10^{17}/\text{cm}^3$. The reduced doping density results in a deeper space charge region (x) in the selenized film. The improvements in J_{sc} is in line with the assumption that higher concentration of the photogenerated carriers can be extracted with lower doping densities and larger grain sizes. Overall series resistance of the devices, Figure 5.4C, does not change significantly with the selenization process. The shunt resistance of the diode, however, is significantly lower for the selenized device. The decrease in the shunt resistance, Figure 5.4D, is mainly due to the poor coverage of the absorber layer across the full electrode area. The exposed back electrode does not contribute to the photocurrent density of the devices, and the shunting deteriorates fill factor of the devices. To fabricate a highly efficient device, it is necessary to reduce void spaces in the selenized absorber layer.

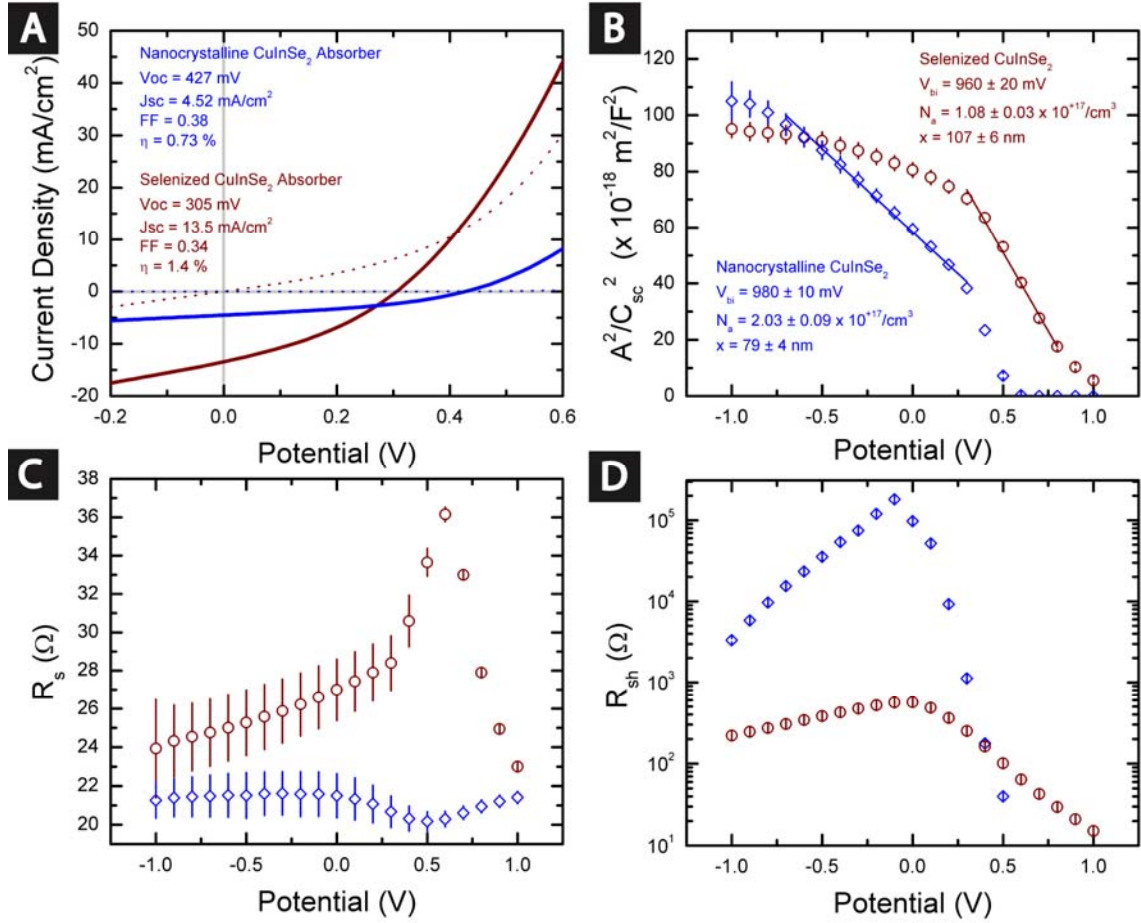


Figure 5.4. (A) IV response of nanocrystalline and selenized CuInSe₂ films. The nanocrystal device (denoted in blue) was built on Au back contacts, and the selenized device (denoted in red) was built based on the Mo back contacts. (B) Mott-Schottky response of the nanocrystal and selenized devices denotes a decrease in the doping density of the absorber layer with increasing grain sizes. The decrease in the doping density, combined with the improved mobility, increases the probability of collection for the photogenerated carriers. (C) Series resistance and (D) shunt resistance of the two diodes at different applied potentials.

The variation in spatial photocurrent density highlights the challenges to fabricating higher efficiency devices. 1) What causes variations in grain growth, and how does the growth pattern translate to final device efficiency. 2) What are the non-crystallized regions in the selenized films and how do they impact the performance. And 3) what are the benefits and issues associated with the MoSe₂ formation during

selenization. The following sections attempt to provide an overview of these variations in the selenized films and how they impact the device efficiency of the selenized nanocrystal layers.

5.3.1 Variations in selenization

Process of selenization has been extensively studied on metal and metal alloy layers. The processing used here is better known as close-spaced vapor transport (CSV T) selenization when applied to metal films.⁶ The CSV T process was used in lieu of other selenization techniques, such as evaporation processing or H₂Se treatment, because of cost and safety. CSV T process was easy to implement and the chamber was confided to reduce selenium leakage. The CSV T selenization is easy to reproduce and all the variables involved with the selenization processes are controlled through temperature of the selenization box. Several disadvantages are associated with this technique and are discussed later in the section.

Selenization of metals and metal alloys with CSV T take place at relatively low temperatures (< 420°C) and CuInSe₂ grain growth is observed at temperatures as low as 240°C.¹² For the selenization of CuInSe₂ nanocrystals, however, no extensive grain growth is observed at temperature below 350°C. CSV T process works at lower temperatures because of the thermodynamically favorable incorporation of selenium to form CuInSe₂. Even though there is a 29 kJ/mol activation energy required for this process,⁶ there is a 312 kJ/mol driving force toward formation of CuInSe₂ from Cu and In alloys.⁵ Since the selenium is already incorporated into the CuInSe₂ nanocrystals, there is no thermodynamic driving force for further incorporation of selenium into the absorber film. As such, a much higher temperature is necessary to induce transport of the

constituent parts into larger grains. For the selenization of nanocrystal grains, thermodynamic driving force involves forming larger crystal grains and reducing surface states.

Selenization of nanocrystal grains into larger crystal structures did not yield homogeneous layers of micron sized grains. Several studies were undertaken to promote growth of the desired domains, while limiting growth of the undesired features. Several key factors were determined to influence the selenization process. Temperature was the key factor in determining growth, and the growth was observed with the selenizations at or above 350°C. Secondly, the geometry of the selenization box controlled adhesion of the selenized film to the back contact. And finally, the composition of the as-cast films played an important role in determining the extent and morphology of grain growth in the films.

Length of selenization, which plays an important role in selenization of metal alloys, did not impact the extent of selenization of nanocrystal inks. Time does play a significant role in the selenization of nanocrystals, but we did not observe any time dependent performance variation. The length of time necessary for the selenization chamber to heat up and cool down was longer than the kinetics of the process. A more rapid selenization procedure is necessary to study the kinetics of CIGS grain growth.

Figure 5.5 shows SEM images of CuInS_2 nanocrystal films selenized at different temperatures. At 350°C larger features are visible on the surface of the nanocrystal layer, and these features are most likely the starting seeds for recrystallization of the CuInSe_2 nanocrystals into larger crystals. Bulk of the film, however, remains as nanocrystals as is evident in cross sectional SEM image, Figure 5.5B. At 400°C, the surface features have

grown larger, and have started to coalesce into larger grains; at the same time, it is evident that a layer of crystals have started forming at the Mo and nanocrystal interface. The two sections of growth are separated by a nearly continuous layer of amorphous by-product of the selenization. At 500°C, majority of the film is recrystallized into larger grains, but several pockets of the amorphous by-product remain. The kinetics of the MoSe₂ formation prevents higher temperature selenization. Reaction of the back contact with the selenium vapor leads to delamination of the back contact at higher temperatures, more on this topic in section 5.3.3.

The higher growth temperatures required to sinter nanocrystalline CIGS crystals into larger grains is understandable. There is a large thermodynamic driving force to form CIGS from the constituent metals, as such, the kinetics of the reaction are relatively rapid at lower temperatures to selenize the metallic films. Since the CIGS crystal is already present in the nanocrystal ink, the driving force is no longer there;. The growth of nanocrystals at this stage resembles the growth of CIGS from CuSe_x and InSe_x precursors. These sub-phases form rapidly during the selenization of the metal alloys, and they diffuse to form larger crystals.¹³ A similar mechanism is dictating the growth of larger crystals in the nanocrystal layer, the CIGS structure could be decomposed to substituent binary products (CuSe_x, InSe_x and GaSe_x) which diffusing to supply larger grains. The diffusion requires a much higher processing temperature than the formation of CIGS from precursor metals.

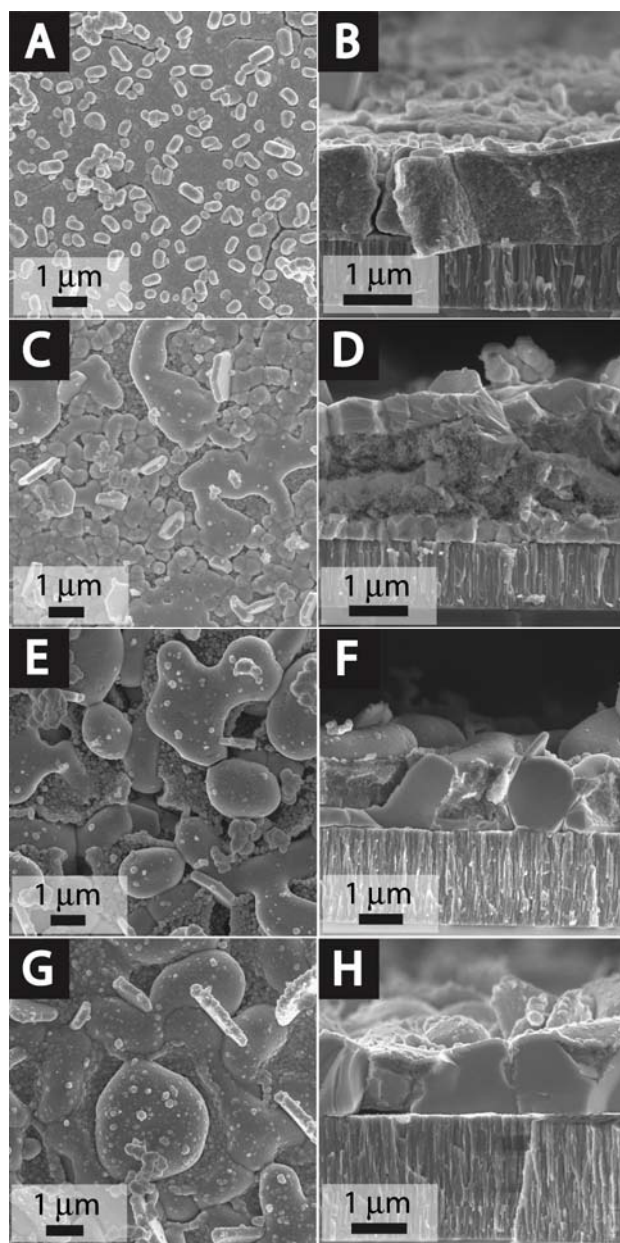


Figure 5.5. SEM of the surface and the cross-section of selenized CuInS_2 nanocrystal films at different temperatures, (A-B) 350°C , (C-D) 400°C , and (E-F) 500°C . (G-H) Correspond to CuInS_2 particles selenized at 500°C but the as-deposited nanocrystal film was treated with hydrazine solution before selenization.

Construction of the selenization box further dictates the uniformity of the selenization process. Figure 5.6 shows SEM images of two identical CIGS nanocrystal films selenized under the same conditions in two different boxes. First box had a loose

fitting cap and while it remained sealed during the selenization process, it was not air-tight. The second box, had a much tighter seal, and it remained air-tight throughout the selenization process. In the first case, Figure 5.6A-B, the absorber layer peeled during the selenization process, revealing the back contact underneath. The peeling is due to buildup of residual stresses during the selenization process and adhesion failure between the CIGS crystals and the back contact. Since exposed back contact does not have any photon-absorbing material, the peeled regions are not contributing to the overall J_{sc} of the devices, as evident in the LBIC map, Figure 5.3C. Selenization in the air-tight box resulted in films that had similar extent of grain growth, Figure 5.6C-D, but adhered much more uniformly to the back contact. The improved uniformity of the resulting film constitutes a doubling of the overall efficiency of the device, stemming from higher J_{sc} and better FF in the device. The exact reason behind the differences in adhesion is still unclear, but must be attributed to the movement of the selenium vapor within the chamber. The air-tight box has minimal drift current of the selenium vapor, while the leaky box is loosing selenium into the furnace. The leaky box creates a flow of selenium through the box. The peeling of absorber layer is not unidirectional, ruling out direct flow resistance as the cause of peeling. The difference could be due to residual oxygen present in the chamber during selenization. Mild oxidation of the back contact takes place in the tightly sealed box. In the leaky box, the flow of fresh selenium purges the process box, reducing possible oxidation. If the oxidized surfaces are more adhesive, there would be greater tolerance of stresses between the two layers. This hypothesis is under further investigation.

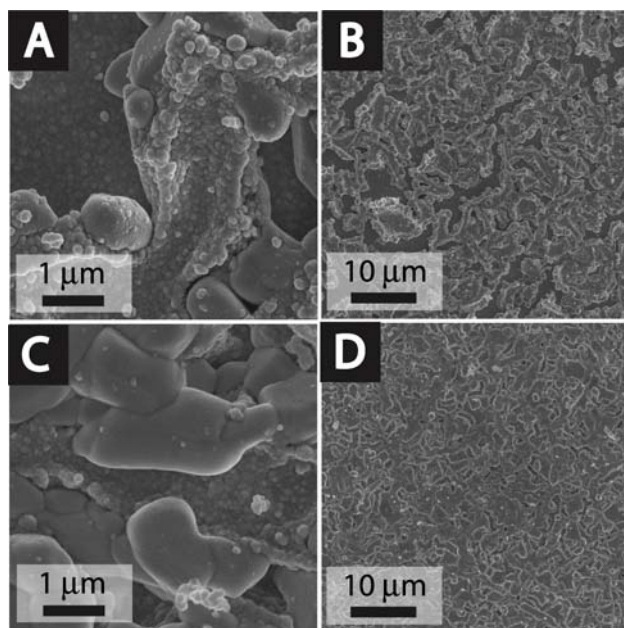


Figure 5.6. SEM of the surface of selenized CIGS nanocrystals at 500°C (A-B) inside a leaky box or (C-D) in a tightly sealed box.

A third variable determining the morphology and the extent of grain growth during the selenization process was the composition of the starting nanocrystalline film. Cu:In ratio in the nanocrystal inks determined the growth pattern. Figure 5.7 illustrates the pattern of crystal growth for three different nanocrystal sets. First selenization set, Figure 5.7A-D, was CuInSe_2 nanocrystal ink synthesized using TCI oleylamine as the solvent and capping ligand during reaction. Based on ICP-ms analysis of the reaction product, the Cu:In ratio was 1:1.55. TEM images of the particle set, Figure 5.7A, reveals irregularly shaped particles. Once selenized at 500°C, the film had extensive grain growth at the back contact interface, mainly in shape of pyramids placed on the surface. Majority of the crystal growth, however, was covered by the presence of the amorphous byproduct. The efficiency of the devices built with this composition nanocrystals, Figure 5.7D, was limited to under 0.3% PCE.

Second product contained CuInSe_2 nanocrystals synthesized using Corsitech oleylamine. Based on ICP-ms analysis, the Cu:In ratio in the ink was 1:1.25. TEM image of the nanocrystal product, Figure 5.7E, reveals nearly spherical products. The resulting selenized film at 500°C reveals crystal growth at two junctions, the nanocrystal/back contact junction and the nanocrystal/ambient junction. The two areas of grain growth are separated with a semi-continuous film of the amorphous byproduct. Devices prepared with this film, Figure 5.7H, exhibit efficiencies consistently above 1% PCE.

Third ink investigated contained CuInS_2 nanocrystals synthesized using TCI oleylamine. ICP-ms measurements of the Cu:In ratio was 1:0.88 for this set of inks. The TEM image of the nanocrystals, Figure 5.7I, show irregular hexagonal disks. The resulting film after selenization at 500°C has higher coverage of the larger crystals on the surface, Figure 5.7J, with larger crystals distributed throughout the depth of the film. Devices built from this particle set, Figure 5.7L, had efficiencies consistently above 2% PCE. The SEM of the selenized film, Figure 5.7J-K, reveals two types of crystal growth. The shapeless growths that indicate the CuInSe_2 crystals dominate the landscape, but there are several irregularly shaped hexagons that protrude above the surface. These shapes visible in SEM images might be indicative of excess Cu forming CuSe_x disks. XRD spectra of the selenized films reveal no crystalline byproduct forming with the selenization of the CuInSe_2 films.

Different morphologies are produced due to differences in position and extent of nucleation in the nanocrystal films. In the highly indium rich product, Figure 5.7A, had very limited nucleation sites; exclusively on the back contact. The less indium rich product exhibited nucleation at the back contact, but had few nucleation points on the

surface. Finally, the indium poor product, Figure 5.7I, had nucleation points distributed throughout the depth of the film. All three films had similar concentration of the amorphous byproduct distributed through the selenized film.

Placement of nucleation points are important for selenization of vapor deposited Cu and In alloys. Most commonly used technique for vapor deposited samples involves a “two step” process.¹⁴ For initial growth stage, it was important to form a indium poor region (usually in the Cu:In ratio of 1:0.8) for the initial seeding of crystals.⁶ Similar nucleation mechanics might be dictating the crystal growth in the selenization of nanocrystal inks as well. In the highly indium rich starting inks, nucleation of new crystals is limited to the back contact, where the crystalline backcontact can act as a nucleation site with access to Na, from the soda lime substrate, can promote larger crystal growths.¹⁵ In the slightly indium rich starting ink, in addition to the back contact, nucleation of larger grains takes place at the ambient interface, where outgassing of In_2Se_3 ⁶ results in regions of indium deficiency. But in the indium poor starting product, nucleation happens along a whole depth of the film. As was observed from the LBIC measurements, Figure 5.3C, larger grains at the top surface are the only grains active at supplying the short circuit current density. Synthesis and selenization of CuInSe_2 nanocrystal inks with overall Cu:In ratio very close to 1:1 is necessary to further investigate the nucleation events.

Two other differences can impact the crystal growth, 1) composition of organic ligand in nanocrystal ink, and 2) replacement of sulfur with selenium in the crystal structure. The organic ligand takes up a large volume fraction of the as deposited films, and with the removal of the organic residue during the selenization process, a large

reduction in the total volume takes place. The reduction is responsible for some of the cracking in the selenized films, Figure 5.3A. Crystal expansion with replacement of sulfur atoms with selenium in the CuInS_2 structure was studied in previous literature.⁴ While both differences could impact final device efficiency, there is little evidence that they are responsible for the nucleation pattern in the films.

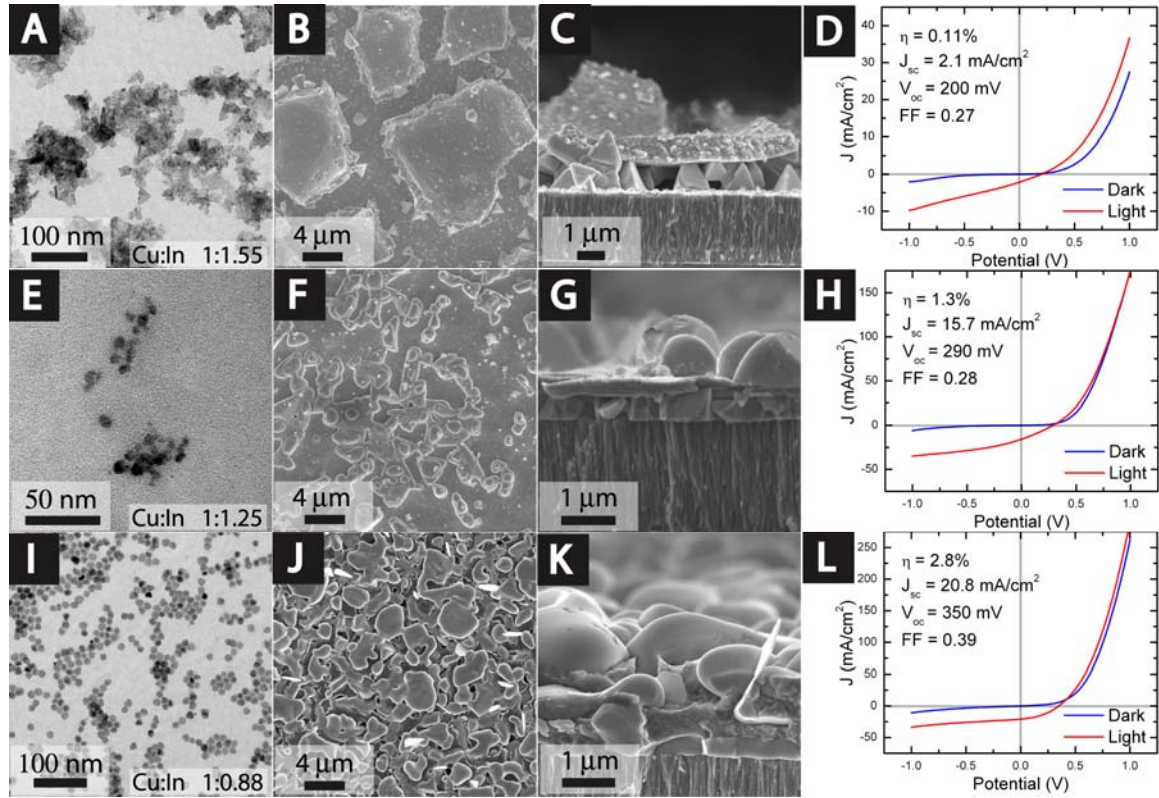


Figure 5.7. TEM images of as-synthesized nanocrystals, surface and cross-sectional SEM of the selenized films and IV response of the fabricated devices with 500°C selenized nanocrystal absorber layers. (A-D) high indium excess CuInS_2 nanocrystal grains, (E-H) lower indium excess CuInS_2 nanocrystal grains, and (I-L) indium deficient CuInS_2 nanocrystal grains. TEM images courtesy of C. Jackson Stolle.

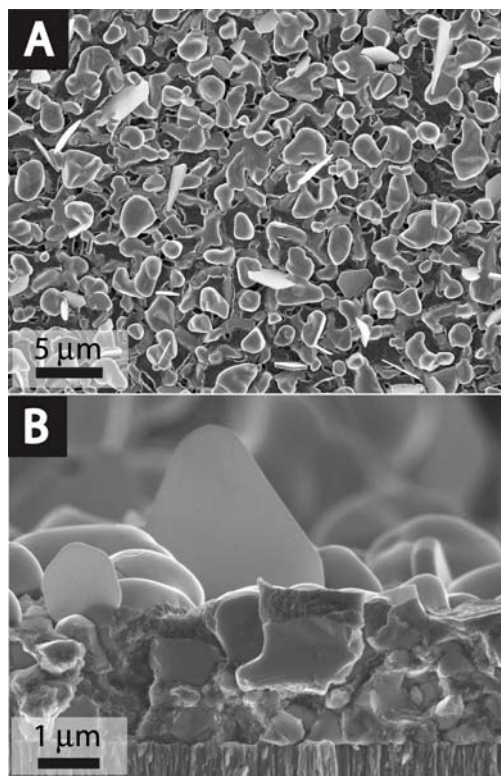


Figure 5.8. (A) Surface SEM and (B) cross-sectional SEM of CuInS_2 nanoparticulates baked at 500°C and then selenized at 500°C .

Further In deficiency could be achieved by pre-baking the indium poor CuInS_2 nanocrystal films at 500°C , followed by selenization at 500°C . Figure 5.8 shows spatial and cross-sectional SEM images of the resulting film. Nucleation in this film is much more wide spread than the unbaked selenization presented in Figure 5.7J-K and as a result, the crystals grown are on average smaller. Devices built from pretreated and then selenized films, however, had lower efficiencies. The deterioration in efficiency was mostly due to higher shunting in the device. The shunting was due to the high concentration of CuSe_x byproduct. Presence of higher concentration of geometrically shaped crystal plates on the surface of the selenized films is indicative of the higher degree of formation for this sub-phase. For vapor deposited samples, KCN etches are

usually performed to etch out the undesired CuSe_x regions. Etching adds another step to device fabrication and was avoided in this work. A route was sought to create more efficient device performance without the need for secondary processing of the absorber layers.

5.3.2 Characterization of the amorphous layer

LBIC maps of the completed devices, Figure 5.3C, reveals how different parts of the absorber layer contribute to the photogenerated current. One of the limiting factors identified is the “unsintered” regions that do not contribute to the photocurrent of the devices. The “unsintered” over layer limits the output of the sintered crystals in two ways. First, the over layer absorbs a fraction of the incident photons, limiting the incident radiation accessible to the sintered grains. Secondly, the presence of the amorphous layer hinders formation of an uninhibited junction between the CIGS absorber and the other layers. XPS spectroscopy of the selenized films were utilized to understand the composition and the oxidation state of the amorphous regions in an attempt to design selenized layers without the amorphous regions that hinder the overall device performance.

Figure 5.9A shows cross sectional SEM image of a selenized CIGS layer. In this case, the crystal growth has taken place exclusively at the back contact interface, and the surface of the crystals is covered by the amorphous layer. XPS measurements of this film, Figure 5.9B, reveal that the composition of the amorphous layer is comprised exclusively of a carbon and selenium mixture. Sputtering of this surface layer with high energy Ar

atoms reveals that the underlying crystal structure is comprised of the Cu, In and Ga of the starting nanocrystal ink, as these indicative peaks appear with further sputtering.

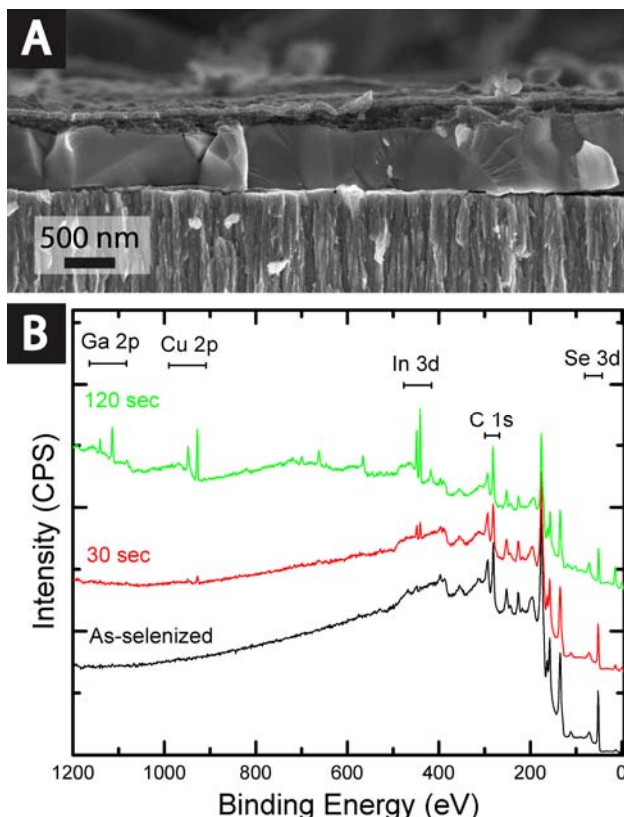


Figure 5.9. (A) Cross-sectional SEM image of a selenized CIGS film, coverage of the amorphous layer on the surface of the selenized crystals limits the performance of the fabricated devices. (B) XPS spectrum of the as-selenized CIGS layer before and after Ar sputtering. Sputtering of the surface layer with high energy Ar exposes the crystalline structure underneath the surface layer of carbon and selenium. The underlying layer had similar composition to that of the starting nanocrystals.

Figure 5.10 shows the high resolution XPS spectra of the CIGS film. The charging for the samples was corrected by shifting the In 3d_{5/2} peak to binding energy of 444.4 eV, which is indicative for indium in the CIGS structure.¹⁶ All the other peaks were shifted with respect to the indium peak. The C 1s peaks indicate that the resulting

carbon present in the top layer is nearly identical to the carbon present on the surface of the as-deposited nanocrystal inks layer. In the case of the as-deposited inks layer, the main peak of the carbon falls at 285.0 eV, which is indicative of hydrocarbons present on the surface;¹⁶ but with the selenization, the main peak of the carbon shifts to a slightly lower binding energy of 284.5 eV, indicating the carbon has taken on a more graphitic nature. The total composition of the carbon on the surface increases with selenization, indicating that the free capping ligand in the film migrates to the surface to be evaporated and taken away. The oleylamine capping ligand is not fully removed at 500°C selenization. Attempts at removing the oleylamine capping ligand prior to selenization was undertaken through chemical treatment with hydrazine. The selenized hydrazine treated films, Figure 5.5G-H, contain much smaller fractions of the amorphous sections. There was, however, little improvements in the overall efficiency of the device when the films were hydrazine treated before selenization.

The Se 3d region of the XPS spectrum, Figure 5.10, reveals deposition of elemental selenium on the surface of the selenized layer. Selenium in the as deposited nanocrystal film has binding energy at 54 eV, and the peak can be deconvoluted into the two spin states of selenium. This position is in good accordance to the value for selenium binding energy in vapor deposited CIGS structure.¹⁶ After selenization, the Se peak shifts to higher binding energy of 55 eV. This bonding energy corresponds to elemental selenium.¹⁶ Selenium is deposited on the surface of the selenized films by condensation of the selenium vapor during the cool down of the selenization box. Deposition of elemental selenium on the surface is detrimental to device performance and must be removed to promote good junction formation between the CIGS and CdS layers.

Thermal treatments are known to remove elemental selenium without hindering the performance of the CIGS device.¹⁷ Figure 5.10 shows evolution of the selenium peak with post-selenization thermal treatment at different temperatures. Thermal annealing is able to remove a fraction of the elemental selenium, but even at 300°C some of the deposited elemental selenium remained. At the same time, the post treatments is unable to remove any of the remaining carbon on top of the selenized film. Little improvement in the overall device efficiency was observed with the removal of the elemental selenium. The limiting factor remains the presence of the carbonaceous film.

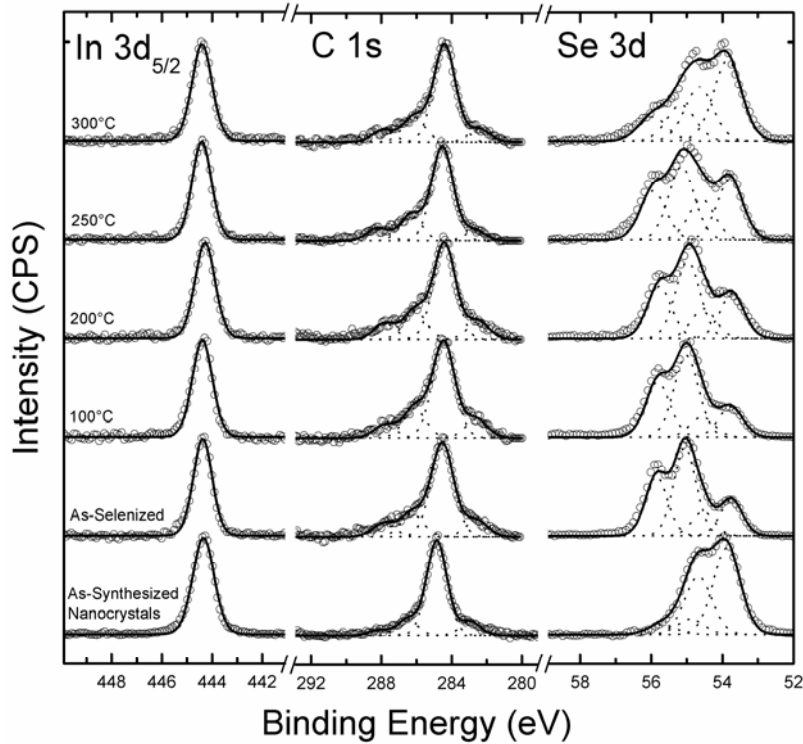


Figure 5.10. High resolution XPS scans of In 3d_{5/2}, C 1s and Se 3d regions of CIGS films before and after selenization at 500°C. Post-baking of the selenized absorber layers for 60 minutes at different temperatures removed some excess elemental selenium but a majority of the carbonaceous material remained. All the peak intensities are normalized for easier viewing.

5.3.3 Formation of MoSe_2

XRD spectrum of the selenized film, Figure 5.2, shows formation of a secondary set of peaks at 31.8° and 56.2° 2θ values which do not correspond with the CuInSe_2 or the Mo back contact. The presence of these peaks indicates formation of MoSe_2 at the interface of the back contact and the absorber materials. MoSe_2 is a semiconductor and is deemed necessary to form high efficiency CIGS devices.¹⁰ As was discussed in chapter 2, the lack of the MoSe_2 layer creates an electronic barrier between as-deposited CIGS nanocrystal films and Mo back contact. MoSe_2 is necessary to form an ohmic contact between the absorber materials and the Mo back contact. Formation of the MoSe_2 , however, brings up several issues associated with the selenization process.

Figure 5.11A shows representative EDS line-scan results running across the depth of a selenized Mo back contact. The presence of the Se along the length of what is considered the back contact shows how much of the Mo present has reacted with the selenium vapor. SEM images of the back contact (Figure 5.11B), shows the $1\text{ }\mu\text{m}$ thick Mo back contact has ballooned into $3\text{ }\mu\text{m}$ through the selenization process. Selenization at 500°C left only 200 nm of Mo metal serving as the back contact. Cross-sectional SEM images of the devices annealed at different temperatures, Figure 5.5, reveals the extent of Se incorporation and MoSe_2 growth is temperature dependent. At 350°C , very little of the Mo has reacted to form MoSe_2 , but at temperatures above 500°C the entire Mo back contact reacts. Once there is no more metallic Mo left adhering to the glass substrate, the film starts to peel away, and devices can no longer be fabricated. This is one issue limiting the selenization procedure to $< 500^\circ\text{C}$.

Another issue with the reaction of Mo and formation of MoSe_2 is the increased resistance of the devices. MoSe_2 , as a semiconductor, has much lower conductivity than the Mo metal. As more of the Mo metal is used up, the series resistance of the devices increases. The increased series resistance reduces the efficiency of the device. The formation of several microns of MoSe_2 is the reason the series resistance of the selenized devices are on par with the nanocrystalline absorber devices, Figure 5.4C.

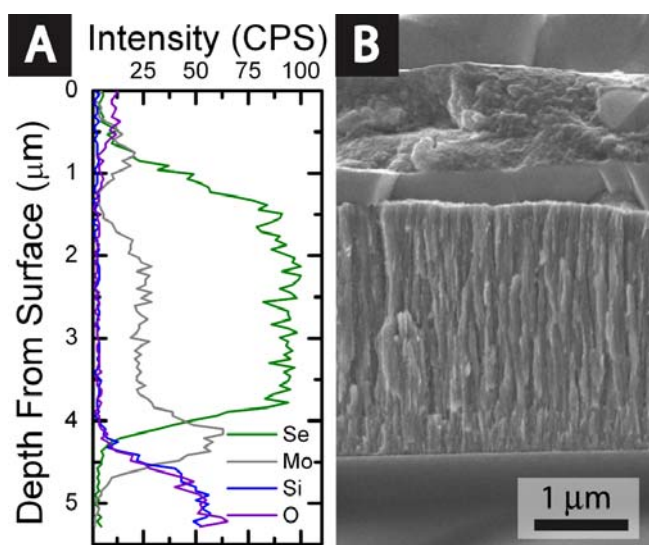


Figure 5.11. (A) EDS line-scan across the (B) cross-sectional SEM of the Mo back contact selenized at 500°C and fabricated into a device. EDS indicates that the majority of the back contact has large concentrations of Se incorporated in with the Mo.

5.4 High Efficiency Selenized Nanocrystal CIGS Devices

Table 5.1 lists best device efficiencies achieved with selenization of different composition CIGS nanocrystal films. Best efficiency devices were fabricated using nanocrystals with targeted composition of $\text{CuIn}_{0.5}\text{Ga}_{0.5}\text{Se}_2$. The IV response of this device is shown in Figure 5.12A. External quantum efficiencies (EQE) measurements, Figure 5.12B, indicate over 50% of the absorbed photons were extracted as current for a

wide range of visible wavelengths. J_{sc} calculated based on the EQE measurements was 20.3 mA/cm^2 , matching well with the J_{sc} measured from the IV results at 20.1 mA/cm^2 . Based on ICP-ms analysis, the measured Ga/(In+Ga) was close to 32% in the as-deposited nanocrystal films. The Ga/(In+Ga) was very close to the 30% observed to produce the highest efficiency vapor deposited CIGS.¹⁰ The Cu:In ratio was measured at 1:0.8, which was very similar to the observed ratio discussed in section 5.3.1 that led to formation of high density of nucleation points in the nanocrystalline films. Presence of the gallium allows for the indium deficiency to exist, but is incorporated into the crystal structure to limit the formation of the undesired CuSe_x sub-phase. At the same time, gallium content enables targeting a specific electronic bandgap to optimize the V_{oc} of the device. Similarly selenized films but with different starting nanocrystal CIGS composition, Table 5.1, yielded lower efficiency devices.

Table 5.1. Measured composition of nanocrystal inks based on ICP-ms analysis for targeted x in $\text{Cu}(\text{In}_{1-x}\text{Ga}_x)\text{Se}_2$ relative to the concentration of Cu present and the best device characteristics based on selenized films of the nanocrystal films.

Target x (%)	Measured Composition				Device Characteristics			
	Cu	In	Ga	Se	V_{oc} (mV)	J_{sc} (mA/cm^2)	FF	PCE (%)
0	1.00	1.55	0.00	2.70	227	2.77	0.29	0.18
15	1.00	1.59	0.05	2.87	240	8.50	0.34	0.69
25	1.00	1.06	0.14	2.28	320	13.59	0.36	1.56
50	1.00	0.83	0.39	2.33	526	20.10	0.48	5.10
75	1.00	0.49	0.82	2.53	478	9.08	0.35	1.51
100	1.00	0.00	1.29	2.46	205	1.81	0.28	0.10

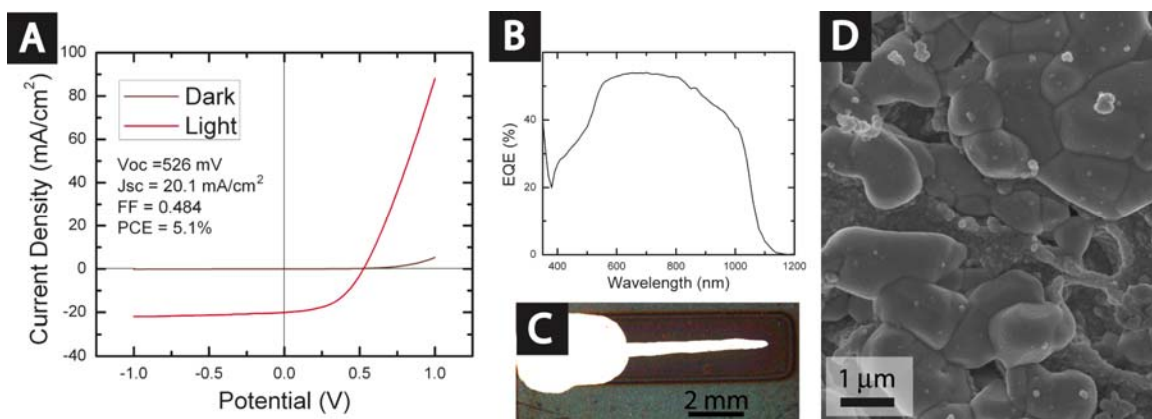


Figure 5.12. (A) IV response of the best efficiency selenized device, (B) IPCE measurement of this device, (C) optical image of the full device, with the painted silver contacts, and (D) SEM of the absorber layer of the selenized film.

Impedance measurements of the highest efficiency selenized device, Figure 5.13, shows doping density in the selenized film to be around $10^{17}/\text{cm}^3$. This doping density is an order of magnitude higher than what is achieved in vapor deposited samples.¹⁰ Reduction of the doping density even further presents an opportunity for achieving higher efficiency devices.

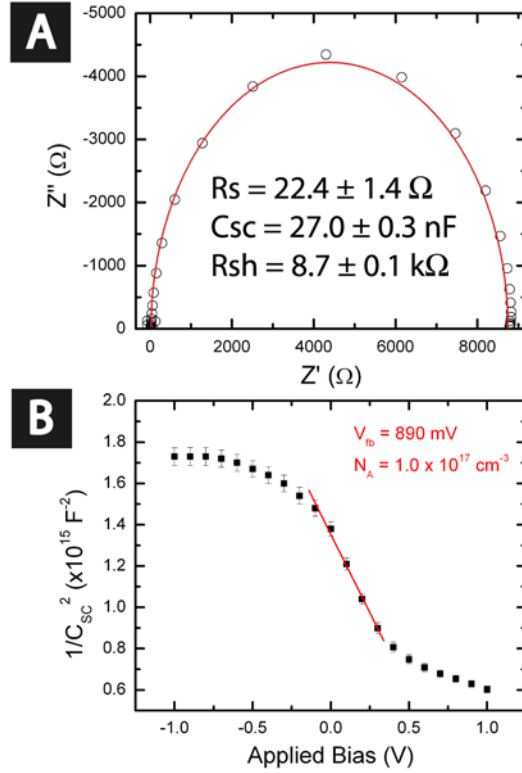


Figure 5.13. (A) Fit of model circuit to impedance measurement of the device at zero bias. (B) Doping characteristics of selenized nanocrystalline films as determined through Mott-Schottky analysis of the impedance results.

5.4.1 Role and purity of CdS layer

As discussed earlier in chapter 3, the photoactivity of the CdS layer plays an important role in electronic band alignment of the device under illumination. Similar trends were observed with the selenized nanocrystal absorber layers. Furthermore, it was discovered that the purity of the precursors necessary for CdS deposition were critical to achieving highly efficient devices. High doping levels in CdS increases the barrier to electron extraction from the absorber layer. The deterioration in efficiency due to impurities in CdS was observed in the fill factor (FF) of the final devices. Figure 5.13 illustrate the IV response under AM1.5 illumination of two similarly selenized CIGS

films, with differences in the DI water used for the chemical bath deposition of the CdS layer. When higher impurities were present in the DI water, an inversion in the IV sweep at 200 mV resulted in unrealistically low FF in the devices of 0.21. Using highly purified DI water, 18.2 M Ω , resulted in elimination of this inversion and achieved much better FF for the device at 0.38.

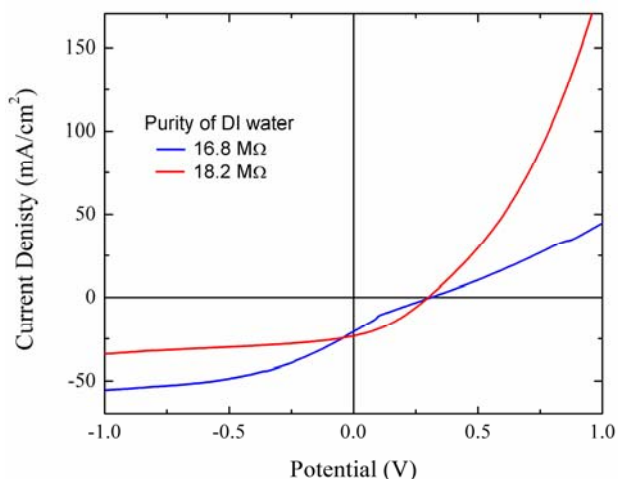


Figure 5.14. Representative IV response under AM 1.5 illumination for devices prepared with different purity CdS layers. The purity of the CdS layer was controlled through the purity of the DI water used. Higher resistance of the water indicates the higher purity of the water.

5.4.2 Retaining flexibility in device architecture

One benefit of using nanocrystalline inks as the precursor for photovoltaic devices involves the flexibility of architecture and design as was illustrated in Chapters 2 and 3. The selenization process significantly reduces the design parameters available for fabrication. One of the goals of this work was to use flexible substrates for device fabrication. Retaining the ability to build lightweight and flexible devices would significantly promote the commercial outlook for this process. Figure 5.15 shows preliminary results of selenized absorber devices on flexible substrates. Devices could be

built on both kapton, Figure 5.15A, or stainless steel, Figure 5.15B, substrates. The flexibility of the final device structure was much poorer than the unselenized absorber layers discussed in chapter 2 and the device efficiencies achieved on the flexible substrates were considerably lower than what was achieved on soda lime glass substrates. Figure 5.15C shows a representative IV response of selenized nanocrystal CIGS devices built on stainless steel substrate. Further work is necessary to understand the limitations of building selenized photovoltaics on flexible substrates and attempt to overcome these challenges.

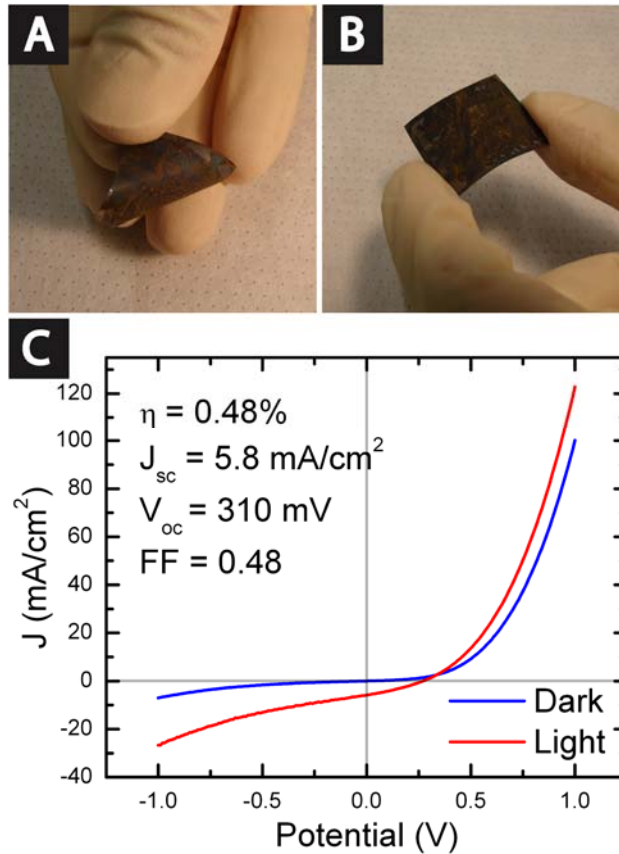


Figure 5.15. Images of flexible devices fabricated on (A) kapton and (B) stainless steel. (C) IV response of flexible device fabricated on stainless steel substrate.

5.4.3 Engineering electronic bandgap based on Ga content of nanocrystal inks

One of the advantages of the CIGS as photovoltaic absorber materials is the ability to target a specific electronic bandgap by targeting a specific ratio of Ga to In in the crystal structure. The ability to control the bandgap through the nanocrystal inks synthesis enables creation the whole spectrum of bandgap energies accessible to CIGS. Table 5.1 lists measured composition of the starting nanocrystal inks for different targeted compositions. Figure 5.16 demonstrates the shift in the $\langle 112 \rangle$ reflection of the XRD pattern as more Ga is incorporated into the crystal before and after selenization. The shift to higher 2θ values are indicative of the smaller element (Ga) replacing a larger element (In) in the crystal structure. Smaller element reduces the lattice constant and increases reflection angle in accordance to Bragg's law. The selenization of the crystals increase the sharpness of the reflection peak, indicating growth to larger crystal sizes. The central position of the peak, however, is retained, indicating the crystallographic structure of the as-deposited and the selenized films are the same. Figure 5.16C shows the IPCE measurements of the selenized absorber devices, the effective band edge of the devices changes according to the targeted composition of the nanocrystals.

Figure 5.17 shows the measured bandgap of the selenized nanocrystalline absorber layers with different Ga concentrations in the starting nanocrystal inks. Comparison to the bandgap values of vapor deposited CIGS with varying Ga concentration⁸ reveals similar trends shared between the two sample sets. The differences between the measured badgap of the selenized nanocrystal absorbers and the vapor deposited absorber is due to the measuring technique used in each case.

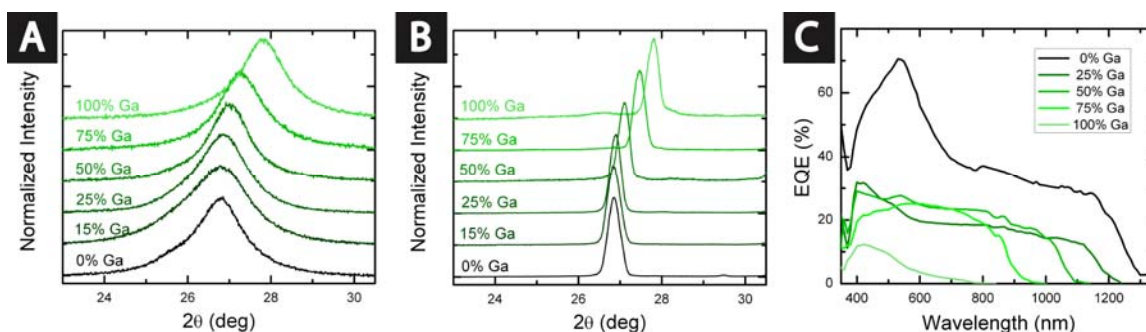


Figure 5.16. $\langle 112 \rangle$ reflection of the XRD pattern for gallium CIGS nanocrystals (A) as cast and (B) after selenization. (C) IPCE measurement of the devices built from selenized films of different Ga CIGS.

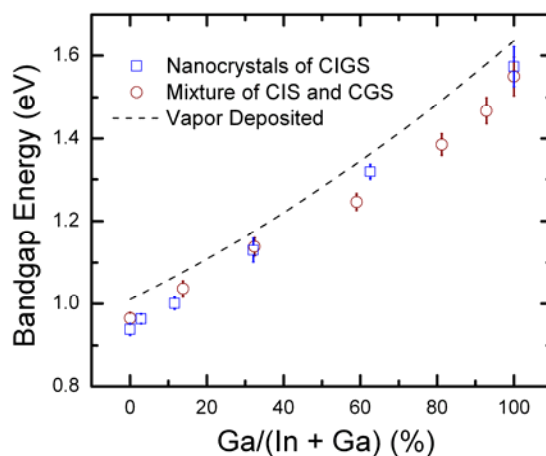


Figure 5.17. Bandgap measurements for the selenized nanocrystal films with different Ga content as determined through IPCE measurements compared to vapor deposited film bandgap measured by fluorescence.⁸

5.5 Summary

Post deposition treatment strategies were explored to increase charge mobilities and reduce doping densities for higher efficiency devices. At 3% PCE, the as-deposited nanocrystal absorbers are not efficient enough for commercialization. Post deposition selenization of CIGS nanocrystal films at 500°C enables efficiencies up to 5.1% PCE.

Several challenges were identified with the selenization process and methods were discussed to resolve these issues and increase the efficiency of the devices even further.

Extent of selenization was strongly impacted by the composition of the starting inks. Extent and morphology of sintering determined the efficiency of the final device. LBIC technique was utilized to characterize specific regions of device and optimize the source of photocurrent. The Ga/(In+Ga) composition determined the bandgap of the materials, and was important to optimize the V_{oc} of the selenized absorber devices. It was demonstrated that selenized nanocrystals with specific Ga concentration had a bandgap energy that matched well with the bandgap of vapor deposited samples with similar Ga concentration. Secondly, Cu:In ratio determines the extent of selenization and the mechanics of crystal growth. A Cu rich nanocrystal film was necessary to seed multiple sites for crystal growth but avoid formation of undesired $CuSe_x$ subphases that act to deteriorate device performance.

The selenization process is not favorable to retain the flexibility of architecture demonstrated for as-deposited nanocrystal devices. It was, however, demonstrated that devices on flexible substrates are possible with selenized nanocrystal absorber layers. Further optimization in processing is needed to further improve the efficiency of these devices. More studies are necessary to understand the mechanics of crystal growth in the nanocrystal films. Lower temperature selenization processes can be devised to fabricate higher efficiency devices on flexible substrates.

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Chapter 6: Conclusions

The technological barrier to photovoltaic (PV) electricity remains the high cost of PV module production. Reliance on silicon as the photon absorbing material and the high temperature processing dictate high production costs for today's PV technology.¹ PV devices that produce electricity at competitive costs with conventional forms of electricity are not yet available. An order of magnitude reduction in module production costs but retaining > 10% power conversion efficiency (PCE) is necessary to design the next generation PV devices that could compete with conventional forms of electricity generation. This work demonstrated a new route to fabricate viable PV devices using $\text{Cu}(\text{In}_{1-x}\text{Ga}_x)\text{Se}_2$ (CIGS) nanocrystal inks deposited under ambient conditions.²

Nanocrystal inks provide a novel way to deposit thin films of inorganic materials without thermal or vacuum treatments. Synthetic procedure for CIGS nanocrystal inks was established by Matthew Panthani and colleagues.³ A spray-deposition process was devised to deposit CIGS nanocrystal layers rapidly and inexpensively under ambient conditions. The layers were then incorporated into functioning devices with reliable and robust PV response. The device efficiencies achieved to date, however, have been relatively low. Without high temperature selenization of CIGS nanocrystal films, PCEs of just above 3% were demonstrated.⁴ Commercial application of these materials requires further improvements in device efficiency. Nonetheless, low temperature solvent-based processing of nanocrystal layers enabled a variety of different material combinations, PV device architectures and substrates that are not possible with high temperature processing.

The main weakness of nanocrystal-based PVs is the inability to extract significant photocurrent. Electron/hole trapping and poor charge mobility limits the overall efficiency of the devices. Carriers could not be efficiently extracted from nanocrystal layers thick enough for optimum photon absorption characteristics. Best efficiency devices were fabricated from nanocrystal devices with less than 200 nm thickness of absorber layer. The thinner devices were not able to absorb a high fraction of the incident spectrum, but converted $> 50\%$ of the absorbed photons to electricity as measured by internal quantum efficiency (IQE) calculations. Higher photocurrents were achieved by stacking multiple junctions with transparent top and bottom contacts, but thus far, the total device efficiency has remained low.²

A combination of synthetic variations and low temperature treatments were investigated to improve collection depth in the nanocrystal layers. These strategies, however, did not result in noticeable improvements in overall device efficiency. For example, hydrazine treatment of as deposited nanocrystal inks removed a fraction of the insulating oleylamine capping ligands, and improved mobility through the nanocrystal film, but the final device efficiencies were lower due to creation of carrier trap sites by removing the capping ligand. Further work is necessary to improve upon these strategies. Perhaps combinations of nanocrystals and 1-D nanorods or nanowires⁵ could reduce the hopping in the nanocrystal films, or the formation of a bulk heterojunctions with greater interfacial contact between *n*- and *p*-type semiconductor layers could lead to better charge collection. Colloidal nanocrystal inks can be deposited under a variety of conditions, providing the means to devise more exotic device geometries. Fabricating low-cost and high efficiency PV devices from as-deposited nanocrystal inks provides the best

opportunity for commercialization, but further research is necessary to design better inks and better device geometries for this purpose.

Another route to fabricate PV devices based on nanocrystal inks deposition involved selenization of the deposited inks to fabricate larger grain devices. Higher carrier mobility and lower doping levels in larger grains overcame the extraction issues encountered with the nanocrystalline grains. Selenization process enabled fabrication of devices with similar efficiencies to vapor deposited samples, but with lower deposition costs. This process retained much of the device architecture and limitations associated with vapor deposited devices, but provided a model for understanding charge collection and mechanics of crystalline grain growth. Hilhouse, Agrawal and coworkers⁶⁻⁸ have shown that high temperature selenization of CIGS-based nanocrystal films can lead to efficiencies comparable to vapor-deposited CIGS devices. My work aimed at identifying milder processing conditions to grow crystalline grains, understand the growth process and further improve device efficiencies.

Selenization of nanocrystalline grains was similar to selenization of vapor deposited metal alloys in some aspects and different in others. The grain growth turned out to be critically dependent on the composition of the starting precursor film and similar to vapor deposited samples, high efficiency devices were fabricated from a narrow range of compositions. At the same time, the thermodynamic driving forces promoting growth of vapor deposited CIGS did not promote grain growth in the nanocrystalline films. As such, higher temperatures were necessary to form dense network of selenized CIGS grains from nanocrystal precursors.

The ratio of Cu:In in the nanocrystal films impacted the growth pattern during selenization. A Cu/In above one was necessary to seed grains, but copper excess led to formation of CuSe_x byproduct that shunted the absorber layer. A copper deficiency was achieved by including gallium in the starting product. While grain growth is responsible for higher carrier mobility and better charge extraction, the placement of the larger grains was critical for charge collection. Light beam induced photocurrent maps (LBIC) were used to identify photoresponse of different regions of the selenized film. Presence of a carbonaceous byproduct film complicated the growth pattern and produced microscopic heterogeneity in the selenized devices. Only the larger grains on the surface were found to actively contribute to the photocurrent from the device.

Similar to vapor deposited CIGS, the Ga composition in the starting film was shown to determine the bandgap of the selenized absorber layers. Measured bandgap values matched well with what has been reported in vapor deposited samples. Optimizing all variable (composition, selenization apparatus and selenization temperature) resulted in selenized nanocrystal CIGS devices with 5.1% efficiency and short circuit current densities above 20 mA/cm^2 .

To design PV devices using CIGS nanocrystalline inks, LBIC⁹ and photoelectrochemical (PEC)¹⁰ measurements were used to accelerate design and implementation new ideas. They will play an important role in future discoveries. Future work requires developing lower temperature or more rapid sintering routes to increase the grain size in as-deposited films. This kind of processing should be enabled by the predetermined crystal structure and composition available through nanocrystal inks deposition. Avoiding addition of excess selenium reduces the processing costs and

complexity. To achieve higher efficiencies, larger and more interconnected grain structure is needed to absorb more photons and extract more carriers. Selenization is the only viable option for now, but it remains a barrier to less expensive device fabrication.

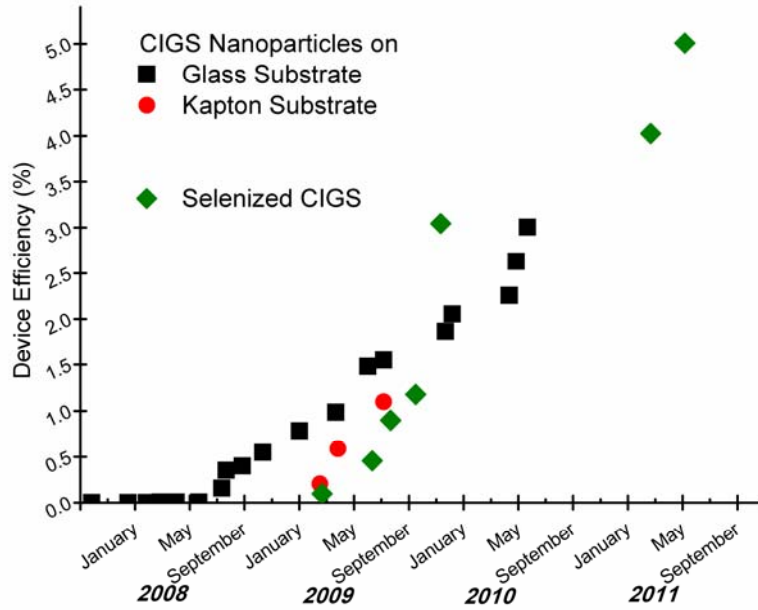


Figure 6.1. Progress timeline for solution processed CIGS devices by ambient deposition of CIGS nanocrystal inks.

Over the past five year, there has been a steady improvement in the demonstrated efficiency of photovoltaic devices fabricated by solution deposition of CIGS nanocrystal inks, Figure 6.1. The main driving force behind the improvement has been a steady march towards reduced impurities in the semiconductor layers, and improved conductivities of electrode materials. Doping levels in the mid to low $10^{17}/\text{cm}^3$ are now achieved in both the nanocrystal absorbers and selenized nanocrystal absorbers. Series resistance of the fabricated devices are now in $100\text{--}150\ \Omega/\text{cm}^2$ range. Devices efficiency could be further improved by reducing the absorber layer doping density to low $10^{16}/\text{cm}^3$,

and reduce total series resistance of the devices below $10 \text{ } \Omega/\text{cm}^2$. A disruptive breakthrough is still necessary to promote this technology to the rank of a commercially viable PV fabrication techniques. Because of the low cost of deposition and the flexibility of device architecture associated with ink based deposition, further interest in this technology is likely.

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Vita

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